

## Position sensor

### Field of the Invention

- 5 The present invention relates to a position sensor device, a position sensor array, a concrete processing apparatus and a method for determining a position of a reciprocating object.

### Description of the Related Art

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For many applications, it is desirable to accurately measure the position of a moving object. For instance, it is highly advantageous to know the position of a reciprocating object to accurately control the reciprocation in an efficient manner.

- 15 According to the prior art, an optical marker can be provided on a reciprocating object, and an optical measurement can be performed to estimate the position of the optical marker and thus a position of the reciprocating object. However, under critical circumstances and conditions such as a dirty environment, the optical marker may be covered by a layer of dirt and may become "invisible" for an optical  
20 detecting means.

Further, in case that the reciprocating object is located in a dirty environment, an optical marker can be abraded by friction between the reciprocating object and dirt particles.

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Such a scenario of critical conditions is present, for instance, in the case of a concrete processing apparatus in which a reciprocating shaft mixes concrete and in which the position of the reciprocating shaft or work cylinder is desired to known to efficiently control the reciprocation cycle.

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Alternatively, a mechanical marker, such as an engraving, can be used as a marker to detect the position or velocity of a reciprocating object. However, such an engraving structure may be filled or covered with dirt and is thus not appropriate to be  
5 implemented under critical and dirty conditions. A mechanical marker (engravings) may also present a challenge to maintain pneumatic or hydraulic sealing.

## 10 Summary of the Invention

It is an object of the present invention to enable an accurate position detection of a reciprocating object capable of being used under critical conditions like a dirty environment.

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This object may be achieved by providing a position sensor device, a position sensor array, a concrete processing apparatus and a method for determining a position of a reciprocating object according to the independent claims.

20 According to an exemplary embodiment of the invention, a position sensor device for determining a position of a reciprocating object is provided, comprising at least one magnetically encoded region fixed on a reciprocating object, at least one magnetic field detector, and a position determining unit. The magnetic field detector is adapted to detect a signal generated by the magnetically encoded region when the  
25 magnetically encoded region reciprocating with the reciprocating object passes a surrounding area of the magnetic field detector. The position determining unit is adapted to determine a position of a reciprocating object based on the detected magnetic signal.

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Further, a position sensor array is provided according to an exemplary embodiment of the invention, comprising a reciprocating object, and a position sensor device having the above-mentioned features for determining a position of the reciprocating  
5 object.

Moreover, a concrete processing apparatus is provided according to another exemplary embodiment of the invention, comprising a concrete processing chamber, a reciprocating shaft arranged in the concrete processing chamber adapted to  
10 reciprocate to mix concrete, and a position sensor device having the above-mentioned features adapted to determine a position of the reciprocating shaft.

Beyond this, a method for determining a position of a reciprocating object is provided according to an exemplary embodiment of the invention, comprising the  
15 steps of detecting a signal by a magnetic field detector, the signal being generated by a magnetically encoded region fixed on a reciprocating object when the magnetically encoded region reciprocating with the reciprocating object passes a surrounding area of the magnetic field detector, and determining a position of a reciprocating object based on the detected signal.

20 One idea of the invention may be seen in the aspect to enable accurate position detection of a reciprocating object, such as a reciprocating working cylinder of a concrete (or cement) processing apparatus, by providing one or more magnetically encoded regions on the reciprocating object. When the reciprocating object  
25 reciprocates, the magnetically encoded region passes – from time to time - an area of sensitivity/a sufficient close vicinity of a magnetic field detector so that a counter electromotive force may be generated in a magnetic coil as a magnetic field detector by which the presence of the magnetically encoded region can be detected. Since the

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position of the magnetically encoded regions on the reciprocating object is known or can be predetermined, the determining unit can derive from the detected signal the actual position of the reciprocating object. To determine the position of the reciprocating object from the detected signal, correlation information can be taken  
5 into account. Such correlation information can be pre-stored in a memory device coupled with the position determining unit and may correlate the presence of a particular signal of a particular magnetically encoded region with a corresponding position of the shaft. In other words, correlation information correlates a detected (electrical) signal with a position of the object.

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“Position” in the context of this description particularly means the information that a particular region or point of the reciprocating object is located at a determined position at a particular point of time.

15 The fact that the magnetically encoded region is fixed on the reciprocating object means that it may be integrated as a part of the object or alternatively may be attached as an external element to the surface of the object.

Particularly, one or more magnetically encoded regions can be formed on different  
20 portions of a hydraulic work cylinder, wherein each of magnetic field detector(s) senses a detecting signal each time a magnetically encoded region traverses a sphere of sensitivity of the magnetic field detector. Thus, the position, the velocity, the acceleration, and so on, of the working cylinder can be estimated with high accuracy, wherein this information can be used to drive the cylinder in a controlled manner to  
25 optimize its function.

Since the detection principle of the invention is contactless, the detection is not disturbed by friction effects and does not require a dirt-free environment. Thus, the

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invention particularly may advantageously be applied in technical fields in which a dirty environment may occur, for instance as a position detecting apparatus for a reciprocating shaft in a concrete processing apparatus, in the field of oil boring, and in the field of mining.

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Further, the magnetic position detecting principle of the invention can be manufactured with low effort, is easy to handle and can be applied to any existing shaft by magnetizing a part of the shaft using a method which will be described in detail below (PCME, "Pulse-Current-Modulated Encoding"). For instance, many industrial  
10 steels used for shafts of an engine or a work cylinder can be magnetized to form a magnetically encoded region of the invention. The detection principle of the invention is very sensitive and provides a good signal to noise ratio.

The invention can be applied to reciprocating objects like a reciprocating shaft  
15 having a full scale measurement range for instance in the range of 1 millimetre to 1 meter, but which may be less than 1 millimetre, or which may be as much as 1 (or more) meters.

The invention particularly allows to identify certain (absolute) positions (or fix  
20 points) on a reciprocating object, like the position where a pump or generator has to be shut off (on-off function). This invention can also be used to make a precise measurement at a specific range on a reciprocating object (defining a linear position on an object).

25 While different types of linear positioning sensors (the concept of which differ fundamentally from the concept of the invention) exist in large quantities and that for a relative long time, this particular invention is particularly designed to function under harsh and abrasive conditions where most other technologies will fail.

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An aspect of a PCME based linear position sensing technology according to an exemplary embodiment of the invention is that the magnetic pick-up device may be very small and therefore can be easily placed in small spaces, like inside of a sealing  
5 chamber in a pneumatic or hydraulic device.

Another benefit is that the magnetic field emanating from the permanent magnetic markers is relatively small and therefore will not attract metallic particles. A typical magnetic proximity sensor (like an automotive wheel-speed sensor) uses very strong  
10 magnetic field to function reliable. Therefore ferromagnetic particles will stick on the surface of such sensors which is why they cannot be used in dirty environments.

The technology of the invention may be also used, in the frame of a concrete processing apparatus, to control the hydraulic cylinder position of the crane arm that  
15 carries the mixed and still liquid concrete mass through a long and flexible pipe to a specific location at a building site.

The hydraulic cylinders need to be extended or contracted so that the height and position of the crane arm can be changed. The PCME magnetic markers are  
20 appropriate to identify the exact position at the cylinder and to detect vibrations or oscillations that are caused by the concrete pump and the pulsing semi-liquid mass in the flexible pipe.

When the crane arm is pulsing/vibrating to much then the pump has to change its  
25 operation to prevent a problem (crane arm is moving outside of the acceptable position tolerance).

Referring to the dependent claims, further exemplary embodiments of the invention

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will be described in the following.

In the following, exemplary embodiments of the position sensor device will be described. However, these embodiments also apply for the position sensor array, the  
5 concrete processing apparatus and the method for determining a position of a reciprocating object.

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The at least one magnetically encoded region of the position sensor device may be a permanent magnetic region. The term "permanent magnetic region" refers to a magnetized material which has a remaining magnetization also in the absence of an external magnetic field. Thus, "permanent magnetic materials include ferromagnetic materials, ferrimagnetic materials, or the like. The material of such a magnetic region  
5 may be a 3d-ferromagnetic material like iron, nickel or cobalt, or may be a rare earth material (4f-magnetism).

The at least one magnetically encoded region may be a longitudinally magnetized  
10 region of the reciprocating object. Thus, the magnetizing direction of the magnetically encoded region may be oriented along the reciprocating direction of the reciprocating object. A method of manufacturing such a longitudinally magnetized region is disclosed, in a different context, in WO 02/063262 A1, and uses a separate magnetizing coil.

15 Alternatively, the at least one magnetically encoded region may be a circumferentially magnetized region of the reciprocating object. Such a circumferentially magnetized region may particularly be adapted such that the at least one magnetically encoded region is formed by a first magnetic flow region  
20 oriented in a first direction and by a second magnetic flow region oriented in a second direction, wherein the first direction is opposite to the second direction.

Thus, the magnetically encoded region may be realized as two hollow cylinder-like structures which are oriented concentrically, wherein the magnetizing directions of  
25 the two concentrically arranged magnetic flow regions are for instance essentially perpendicular to one another. Such a magnetic structure can be manufactured by the PCME method described below in detail, i.e. by directly applying a magnetizing electrical current to the reciprocating object made of a magnetizable material. To



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produce the two opposing magnetizing flow portions, current pulses can be applied to the shaft.

Referring to the described embodiment, in a cross-sectional view of the reciprocating object, there may be a first (circular) magnetic flow having the first direction and a first radius and the second (circular) magnetic flow having the second direction and a second radius, wherein the first radius is larger than the second radius.

Alternatively, the at least one magnetically encoded region may be a (separate) magnetic element attached to the surface of the reciprocating object. Thus, an external element can be attached to the surface of the reciprocating object in order to form a magnetically encoded region. Such a magnetic element can be attached to the reciprocating object by adhered it (e.g. using glue), or may alternatively be fixed on the reciprocating shaft using the magnetic forces of the magnetic element.

Instead of attaching a magnetic object to the surface of the reciprocating object, it is also possible to use materials with different magnetic properties (one material has a higher, and the other a lower permeability, for example). The magnetic object can be attached from the outside of the shaft/cylinder or can be placed inside of the cylinder.

When using materials of different permeabilities, then an additional magnetic encoding of the shaft or cylinder is no longer necessary. An external magnetic source can be used (in conjunction with the magnetic pick-up device) to detect when the magnetic flux is changing as a consequence of the moving shaft.

Any of the magnetic field detectors may comprise a coil having a coil axis oriented essentially parallel to a reciprocating direction of the reciprocating object. Further, any of the magnetic field detectors may be realized by a coil having a coil axis

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oriented essentially perpendicular to a reciprocating direction of the reciprocating object. A coil being oriented with any other angle between coil axis and reciprocating direction is possible and falls under the scope of the invention.

Alternatively to a coil in which the moving magnetically encoded region may induce an induction voltage by modulating the magnetic flow through the coil, a Hall-effect probe may be used as magnetic field detector making use of the Hall effect.

Alternatively, a Giant Magnetic Resonance magnetic field sensor or a Magnetic Resonance magnetic field sensor may be used as a magnetic field detector. However, any other magnetic field detector may be used to detect the presence or absence of one of the magnetically encoded regions in a sufficient close vicinity to the respective magnetic field detector.

A plurality of magnetically encoded regions may be fixed on the reciprocating object. By providing a plurality of magnetically encoded regions, a number of fixed points on the reciprocating shaft are defined which may be detected separately so that the number of detection signals is increased. Consequently, the sensitivity and the accuracy of the position detection may be improved.

The plurality of magnetically encoded regions may be arranged on the reciprocating object at constant distances from one another. Thus, each time one of the magnetically encoded regions passes one of the magnetic field detectors, the reciprocating object has moved by a distance which equals the distance between the magnetically encoded regions. Thus, the position of the reciprocating shaft can be estimated in a time-dependent manner with high accuracy.

Alternatively, the plurality of magnetically encoded regions may be arranged on the reciprocating object at different distances from one another. For instance, the different distances may be selectively based on a linear function, on a logarithmic

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function or by a power function (for instance a power of two or of three). Thus, the time between the detection of subsequent signals by one of the magnetic field detectors follows the mathematical function according to which the magnetic encoding regions of the invention are separated from one another. This allows a  
5 unique assignment of the present position of the reciprocating object.

Such a mathematical function can be a positive (increasing) function or a negative (decreasing) function, meaning that the spacing can become larger from one to the next magnetic marker, or it can become smaller from one to the next.

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The plurality of magnetically encoded regions may be arranged on the reciprocating object with constant dimensions. A constant dimension (e.g. constant width, constant thickness, etc.) yields signals of a constant length in time as detected by any of the magnetic field detectors. However, in a scenario in which the reciprocating object  
15 reciprocates with a non-constant velocity, the length of the signals will change, so that velocity and acceleration information can be determined from the length of the signal in time.

Alternatively, the plurality of magnetically encoded regions may be arranged on the  
20 reciprocating object with different dimensions. This, similar to the case of providing the magnetically encoded regions at different distances from one another, allows a unique assignment of the magnetically encoded region which presently passes one of the magnetic field detectors.

25 Thus, the magnetic markers can be either all of the same physical dimensions (same width) or they can be of different dimensions (like becoming larger one-after-each-other). In the same way the physical dimensions of the markers can be changed, so can be their signal strength. For example: The markers are all of the same physical

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dimensions and they are all placed one-after-each-other with the same spacing to each other. The difference from one marker to the next is that the signal amplitude (generated by the permanently stored magnetic field, inside the marker) is increasing from one marker to the next.

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Different magnetically encoded regions may be provided made of different magnetic materials, and/or may be provided with different values of magnetization. According to this embodiment, the amplitude or strength of the individual detection signals are different for each of the magnetically encoded regions so that a unique assignment of  
10 a detection signal to one of the magnetically encoded regions, being the origin for such a signal, can be carried out.

The position sensor device according to the invention may comprise a plurality of magnetic field detectors. This further allows to refine the detection performance.

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The plurality of magnetic field detectors may be arranged along the reciprocating object at constant distances from one another.

Alternatively, the plurality of magnetic field detectors may be arranged along the  
20 reciprocating object at different distances from another.

The different distances may be selected based on a linear function, a logarithmic function or a power function.

25 Such a mathematical function can be a positive (increasing) function or a negative (decreasing) function, meaning that the spacing can become larger from one to the next detector, or it can become smaller from one to the next.

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The position sensor device according to the invention may comprise a plurality of magnetically encoded regions fixed on the reciprocating object and may comprise a plurality of magnetic field detectors.

- 5 The arrangement of the plurality of magnetically encoded regions along the reciprocating object may correspond to the arrangement of the plurality of magnetic field detectors. In other words, the arrangement of the magnetic encoded regions may be symmetrical and may thus correspond to the arrangement of the magnetic field detectors. In other words, in a reference position of the reciprocating object, a central  
10 axis of each of the magnetic field detectors may correspond to a central axis of a corresponding one of the magnetically encoded regions.

- Alternatively, at least a part of the plurality of magnetic field detectors may be arranged displaced from an arrangement of a corresponding one of the plurality of  
15 magnetically encoded regions arranged along the reciprocating object. According to this embodiment, an asymmetric configuration and arrangement of magnetic field detectors with respect to corresponding magnetically encoded regions in a reference state of the reciprocating object is achieved. For example, a first magnetically encoded region may have its central axis aligned in accordance with a central axis of  
20 a corresponding magnetic field detector. For a second magnetically encoded region, in the reference state, the central axis may be displaced with respect to a central axis of a corresponding magnetic field detector, and so on. Such a geometric offset may be used to improve the performance of the position sensor device, since the signals occur in a timely shifted manner, thus increasing the amount of detection information  
25 and allowing to refine the position determination.

The number of magnetically encoded regions may differ from the number of magnetic field detectors. For example, there may be provided three magnetically

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encoded regions and four magnetic field detectors. Or, two magnetic field detectors may be provided for each of the magnetically encoded regions. Or, a plurality of magnetic field detectors may be provided for each of the magnetically encoded regions, wherein the number of magnetically field detectors for any of the  
5 magnetically encoded regions may differ for different magnetically encoded regions.

In the position sensor device, the reciprocating object can be a push-pull-rod in a gearbox of a vehicle. In an automatic automotive gearbox system, the position of the various tooth-wheels (gear-wheels) may be changed by push-pull-rods. The actual  
10 position of such a rod can be measured with the position sensor device.

In the following, exemplary embodiments of the position sensor array of the invention will be described. These embodiments apply also for the position sensor device, for the concrete processing apparatus and for the method of determining a  
15 position of a reciprocating object.

In the position sensor array, the reciprocating object may be a shaft. Such a shaft can be driven by an engine, and may be, for example, a hydraulically driven work  
20 cylinder of a concrete processing apparatus.

The magnetically encoding region may be provided along a part of the length of the reciprocating object. In other words, any of the magnetically encoded regions may extend along a portion of the reciprocating object in longitudinal direction, wherein another portion of the reciprocating object is free of a magnetically encoding region.  
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Alternatively, the magnetically encoded region may be provided along the entire length of the reciprocating object. According to this embodiment, the whole reciprocating object is magnetized.

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The reciprocating object may be divided into a plurality of equally spaced segments, each segment comprising one magnetically encoded region, the magnetically encoded regions of the segments being arranged in an asymmetric manner. For  
5 instance, three segments may be provided, wherein the first segment has a magnetically encoded region in the first third of its length, the second segment has a magnetically encoded region in the middle third of its length and the third and last segment has the magnetically encoded region in the last third of its length. Such a configuration gradually increases the spacing between consecutive markers yielding  
10 a characteristic signal pattern allowing an accurate estimation of the reciprocating shaft position.

Further, a control unit may be provided in the position sensor array adapted to control the reciprocation of the reciprocating object based on the determined position  
15 of the reciprocating object which is provided to the control unit by the position sensor device. Thus, the output of the position sensor device, namely the present position of the reciprocating object, is provided to the control unit as feedback information. Based on this back coupling, the control unit can adjust a controlling signal for controlling the reciprocation of the reciprocating object to ensure a proper  
20 operation of the reciprocating object.

In the following, exemplary embodiments of the concrete processing apparatus will be described. These embodiments also apply to the position sensor device, the position sensor array and the method for determining a position of a reciprocating  
25 object.

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In a concrete processing apparatus, a control unit may be provided adapted to control the reciprocation of the reciprocating shaft based on the position of the reciprocating shaft which is provided to the control unit by the position sensor device.

- 5 The concrete processing apparatus may further comprise a vehicle on which the concrete processing chamber, the reciprocating shaft and the position sensor device may be mounted. Thus, a mobile concrete processing apparatus provided on a vehicle is created which can be flexibly transported to a place of installation.
- 10 The concrete processing apparatus of the invention may further comprise a further reciprocation shaft arranged in the concrete processing chamber adapted to reciprocate to mix concrete material. The reciprocating shaft and the further reciprocating shaft are operable in a countercyclical manner. In other words, two reciprocating shafts or cylinders may be provided to mix concrete material, wherein
- 15 the two reciprocating shafts move in opposite directions in each operation state. For instance, in a scenario in which the first reciprocation shaft moves in a forward direction, the second reciprocation shaft moves in the backwards direction, and vice versa. By taking this measure, an excellent mixture of the concrete in the concrete processing apparatus is achieved. In order to accurately control the mixing of the
- 20 concrete by the two reciprocating shafts, it is necessary to control the motion of the reciprocating shafts on the basis of estimated position information generated by the position sensor device. Particularly, in an operation state of the reciprocating shafts, in which they change their motion direction, it is particularly important to control the operation of the reciprocating shafts, since the energy consumption in this state is
- 25 particularly high.

In the following, further aspects of the invention will be described which fall under the scope of the invention.



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An amplitude, an algebraic sign, and/or a slope of a detected signal can be used to derive direction information, i.e. to determine if the reciprocating object moves from a first direction to a second direction or from the second direction to the first direction. According to the invention, one signal or a plurality of signals may be analyzed/evaluated to allow an unambiguous assignment of the detection signals to a position of the reciprocating object to be detected. The arrangement of the magnetic field detectors and of the magnetically encoded regions is for instance selected such that a signal sequence of the magnetic field detectors is unique with respect to a particular position of the reciprocating object.

The magnetic position detection principle of the invention, in contrast to optical or mechanical marker detection methods, is abrasion free and operates without errors even in a scenario in which critical conditions (like concrete powder or other kind of dirt) are present.

Further, the magnetic position detection principle of the invention can be used in a wide temperature range. The only physical restriction concerning the temperature range in which the magnetic detection principle of the invention may be implemented is the Currie temperature of the used magnetic material. Thus, the magnetic components of the system of the invention can be used – with a reciprocating object made of industrial steel – up to 400°C and more. A limiting factor for the maximum operation temperature of the system of the invention may be the temperature up to which an isolation of a coil as a magnetic field detector keeps intact. However, with available coils, a temperature of at least 210°C can be obtained. Thus, the system of the invention is very temperature stable. Since the detection principle of the invention is contactless, a cooling element can be provided

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in an environment in which very high temperatures are present. Such a cooling element can be a water cooling element, for instance.

5 The lengths of a reciprocating shaft for an implementation in a concrete processing apparatus may be 5 meters and more.

In principle, using one magnetic field detector, for instance one coil, is sufficient. However, in order to eliminate the influence of the magnetic field of the earth, two detection coils may be used with oppositely oriented coil axis, so that the influence  
10 of the earth magnetic field can be eliminated by considering the two signals of the two coils. The detection of the position can include counting the number of markers which pass one or more magnetic field detectors per time.

The above and other aspects, objects, features and advantages of the present  
15 invention will become apparent from the following description and the appended claim, taken in conjunction with the accompanying drawings in which like parts or elements are denoted by like reference numbers.

## 20 Brief Description of the Drawings

The accompanying drawings, which are included to provide a further understanding of the invention and constitute a part of the specification illustrate embodiments of  
25 the invention.

In the drawings:

Fig. 1 shows a torque sensor with a sensor element according to an exemplary embodiment of the present invention for explaining a method of manufacturing a torque sensor according to an exemplary embodiment of the present invention.

5 Fig. 2a shows an exemplary embodiment of a sensor element of a torque sensor according to the present invention for further explaining a principle of the present invention and an aspect of an exemplary embodiment of a manufacturing method of the present invention.

10 Fig. 2b shows a cross-sectional view along AA' of Fig. 2a.

Fig. 3a shows another exemplary embodiment of a sensor element of a torque sensor according to the present invention for further explaining a principle of the present invention and an exemplary embodiment of a method of manufacturing a torque  
15 sensor according to the present invention.

Fig. 3b shows a cross-sectional representation along BB' of Fig. 3a.

Fig. 4 shows a cross-sectional representation of the sensor element of the torque  
20 sensor of Figs. 2a and 3a manufactured in accordance with a method according to an exemplary embodiment of the present invention.

Fig. 5 shows another exemplary embodiment of a sensor element of a torque sensor according to the present invention for further explaining an exemplary embodiment  
25 of a manufacturing method of manufacturing a torque sensor according to the present invention.

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Fig. 6 shows another exemplary embodiment of a sensor element of a torque sensor according to the present invention for further explaining an exemplary embodiment of a manufacturing method for a torque sensor according to the present invention.

- 5    Fig. 7 shows a flow-chart for further explaining an exemplary embodiment of a method of manufacturing a torque sensor according to the present invention.

Fig. 8 shows a current versus time diagram for further explaining a method according to an exemplary embodiment of the present invention.

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Fig. 9 shows another exemplary embodiment of a sensor element of a torque sensor according to the present invention with an electrode system according to an exemplary embodiment of the present invention.

- 15    Fig. 10a shows another exemplary embodiment of a torque sensor according to the present invention with an electrode system according to an exemplary embodiment of the present invention.

- 20    Fig. 10b shows the sensor element of Fig. 10a after the application of current surges by means of the electrode system of Fig. 10a.

Fig. 11 shows another exemplary embodiment of a torque sensor element for a torque sensor according to the present invention.

- 25    Fig. 12 shows a schematic diagram of a sensor element of a torque sensor according to another exemplary embodiment of the present invention showing that two magnetic fields may be stored in the shaft and running in endless circles.

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Fig. 13 is another schematic diagram for illustrating PCME sensing technology using two counter cycle or magnetic field loops which may be generated in accordance with a manufacturing method according to the present invention.

- 5 Fig. 14 shows another schematic diagram for illustrating that when no mechanical stress is applied to the sensor element according to an exemplary embodiment of the present invention, magnetic flux lines are running in its original paths.

Fig. 15 is another schematic diagram for further explaining a principle of an  
10 exemplary embodiment of the present invention.

Fig. 16 is another schematic diagram for further explaining the principle of an exemplary embodiment of the present invention.

- 15 Figs. 17 – 22 are schematic representations for further explaining a principle of an exemplary embodiment of the present invention.

Fig. 23 is another schematic diagram for explaining a principle of an exemplary  
20 embodiment of the present invention.

Figs. 24, 25 and 26 are schematic diagrams for further explaining a principle of an exemplary embodiment of the present invention.

- Fig. 27 is a current versus time diagram for illustrating a current pulse which may be  
25 applied to a sensor element according to a manufacturing method according to an exemplary embodiment of the present invention.

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Fig. 28 shows an output signal versus current pulse length diagram according to an exemplary embodiment of the present invention.

5 Fig. 29 shows a current versus time diagram with current pulses according to an exemplary embodiment of the present invention which may be applied to sensor elements according to a method of the present invention.

Fig. 30 shows another current versus time diagram showing an exemplary embodiment of a current pulse applied to a sensor element such as a shaft according  
10 to a method of an exemplary embodiment of the present invention.

Fig. 31 shows a signal and signal efficiency versus current diagram in accordance with an exemplary embodiment of the present invention.

15 Fig. 32 is a cross-sectional view of a sensor element having an exemplary PCME electrical current density according to an exemplary embodiment of the present invention.

Fig. 33 shows a cross-sectional view of a sensor element and an electrical pulse  
20 current density at different and increasing pulse current levels according to an exemplary embodiment of the present invention.

Figs. 34a and 34b show a spacing achieved with different current pulses of magnetic flows in sensor elements according to the present invention.  
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Fig. 35 shows a current versus time diagram of a current pulse as it may be applied to a sensor element according to an exemplary embodiment of the present invention.

Fig. 36 shows an electrical multi-point connection to a sensor element according to an exemplary embodiment of the present invention.

5 Fig. 37 shows a multi-channel electrical connection fixture with spring loaded contact points to apply a current pulse to the sensor element according to an exemplary embodiment of the present invention.

Fig. 38 shows an electrode system with an increased number of electrical connection points according to an exemplary embodiment of the present invention.

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Fig. 39 shows an exemplary embodiment of the electrode system of Fig. 37.

Fig. 40 shows shaft processing holding clamps used for a method according to an exemplary embodiment of the present invention.

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Fig. 41 shows a dual field encoding region of a sensor element according to the present invention.

20 Fig. 42 shows a process step of a sequential dual field encoding according to an exemplary embodiment of the present invention.

Fig. 43 shows another process step of the dual field encoding according to another exemplary embodiment of the present invention.

25 Fig. 44 shows another exemplary embodiment of a sensor element with an illustration of a current pulse application according to another exemplary embodiment of the present invention.

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Fig. 45 shows schematic diagrams for describing magnetic flux directions in sensor elements according to the present invention when no stress is applied.

5 Fig. 46 shows magnetic flux directions of the sensor element of Fig. 45 when a force is applied.

Fig. 47 shows the magnetic flux inside the PCM encoded shaft of Fig. 45 when the applied torque direction is changing.

10 Fig. 48 shows a 6-channel synchronized pulse current driver system according to an exemplary embodiment of the present invention.

Fig. 49 shows a simplified representation of an electrode system according to another exemplary embodiment of the present invention.

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Fig. 50 is a representation of a sensor element according to an exemplary embodiment of the present invention.

20 Fig. 51 is another exemplary embodiment of a sensor element according to the present invention having a PCME process sensing region with two pinning field regions.

Fig. 52 is a schematic representation for explaining a manufacturing method according to an exemplary embodiment of the present invention for manufacturing a  
25 sensor element with an encoded region and pinning regions.

Fig. 53 is another schematic representation of a sensor element according to an exemplary embodiment of the present invention manufactured in accordance with a



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manufacturing method according to an exemplary embodiment of the present invention.

Fig. 54 is a simplified schematic representation for further explaining an exemplary  
5 embodiment of the present invention.

Fig. 55 is another simplified schematic representation for further explaining an exemplary embodiment of the present invention.

10 Fig. 56 shows an application of a torque sensor according to an exemplary embodiment of the present invention in a gear box of a motor.

Fig. 57 shows a torque sensor according to an exemplary embodiment of the present invention.

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Fig. 58 shows a schematic illustration of components of a non-contact torque sensing device according to an exemplary embodiment of the present invention.

Fig. 59 shows components of a sensing device according to an exemplary  
20 embodiment of the present invention.

Fig. 60 shows arrangements of coils with a sensor element according to an exemplary embodiment of the present invention.

25 Fig. 61 shows a single channel sensor electronics according to an exemplary embodiment of the present invention.

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Fig. 62 shows a dual channel, short circuit protected system according to an exemplary embodiment of the present invention.

5 Fig. 63 shows a sensor according to another exemplary embodiment of the present invention.

Fig. 64 illustrates an exemplary embodiment of a secondary sensor unit assembly according to an exemplary embodiment of the present invention.

10 Fig. 65 illustrates two configurations of a geometrical arrangement of primary sensor and secondary sensor according to an exemplary embodiment of the present invention.

15 Fig. 66 is a schematic representation for explaining that a spacing between the secondary sensor unit and the sensor host is preferably as small as possible.

Fig. 67 is an embodiment showing a primary sensor encoding equipment.

20 Fig.68 shows a position sensor array according to a first embodiment of the invention.

Fig.69 shows a position sensor array according to a second embodiment of the invention.

25 Fig.70 shows a position sensor array according to a third embodiment of the invention.

Fig.71 shows a position sensor array according to a forth embodiment of the invention.

5 Fig.72 shows a position sensor array according to a fifth embodiment of the invention.

Fig.73 shows a diagram illustrating a detection signal as detected by the magnet field detection coil of the position sensor array according to the forth embodiment of the invention.  
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Fig.74 shows a position sensor array according to a sixth embodiment of the invention.

Fig.75 shows a diagram illustrating a detection signal as detected by the magnet field detection coil of the position sensor array according to the sixth embodiment of the invention.  
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Fig.76 shows a position sensor array according to a seventh embodiment of the invention.  
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Fig.77 shows a concrete processing apparatus according to a first embodiment of the invention.

Fig.78 shows a concrete processing apparatus according to a second embodiment of the invention.  
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Fig.79 and Fig.80 show schematic views illustrating a sequence of signals captured by three magnetic field detectors generated by six magnetic encoded regions

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provided on a reciprocating shaft of a position sensor array according to an eighth embodiment of the invention.

5 Fig.81 and Fig.82 show schematic views illustrating a sequence of signals captured by two magnetic field detectors generated by six magnetic encoded regions provided on a reciprocating shaft of a position sensor array according to a ninth embodiment of the invention.

10 Fig.83 shows a schematic view illustrating a sequence of signals captured by one magnetic field detector generated by six magnetic encoded regions provided on a reciprocating shaft of a position sensor array according to a tenth embodiment of the invention.

15 Fig.84 to Fig.86 show hollow tubes as reciprocating objects with different embodiments for magnetic encoded regions arranged inside the hollow tube.

Fig.87, Fig.88 show a position sensor array according to an eleventh embodiment of the invention.

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#### Detailed Description of Exemplary Embodiments of the Invention

It is disclosed a sensor having a sensor element such as a shaft wherein the sensor element may be manufactured in accordance with the following manufacturing steps

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- applying a first current pulse to the sensor element;
- wherein the first current pulse is applied such that there is a first current flow in a first direction along a longitudinal axis of the sensor element;

- 29 -

- wherein the first current pulse is such that the application of the current pulse generates a magnetically encoded region in the sensor element.

It is disclosed that a further second current pulse may be applied to the sensor  
5 element. The second current pulse may be applied such that there is a second current flow in a direction along the longitudinal axis of the sensor element.

It is disclosed that the directions of the first and second current pulses may be opposite to each other. Also, each of the first and second current pulses may have a  
10 raising edge and a falling edge. For instance, the raising edge is steeper than the falling edge.

It is believed that the application of a current pulse may cause a magnetic field structure in the sensor element such that in a cross-sectional view of the sensor  
15 element, there is a first circular magnetic flow having a first direction and a second magnetic flow having a second direction. The radius of the first magnetic flow may be larger than the radius of the second magnetic flow. In shafts having a non-circular cross-section, the magnetic flow is not necessarily circular but may have a form essentially corresponding to and being adapted to the cross-section of the respective  
20 sensor element.

It is believed that if no torque is applied to a sensor element, there is no magnetic field or essentially no magnetic field detectable at the outside. When a torque or force is applied to the sensor element, there is a magnetic field emanated from the  
25 sensor element which can be detected by means of suitable coils. This will be described in further detail in the following.

- 30 -

A torque sensor may have a circumferential surface surrounding a core region of the sensor element. The first current pulse is introduced into the sensor element at a first location at the circumferential surface such that there is a first current flow in the first direction in the core region of the sensor element. The first current pulse is  
5 discharged from the sensor element at a second location at the circumferential surface. The second location is at a distance in the first direction from the first location. The second current pulse may be introduced into the sensor element at the second location or adjacent to the second location at the circumferential surface such that there is the second current flow in the second direction in the core region or  
10 adjacent to the core region in the sensor element. The second current pulse may be discharged from the sensor element at the first location or adjacent to the first location at the circumferential surface.

As already indicated above, the sensor element may be a shaft. The core region of  
15 such shaft may extend inside the shaft along its longitudinal extension such that the core region surrounds a center of the shaft. The circumferential surface of the shaft is the outside surface of the shaft. The first and second locations are respective circumferential regions at the outside of the shaft. There may be a limited number of contact portions which constitute such regions. For instance, real contact regions may  
20 be provided, for example, by providing electrode regions made of brass rings as electrodes. Also, a core of a conductor may be looped around the shaft to provide for a good electric contact between a conductor such as a cable without isolation and the shaft.

25 The first current pulse and also the second current pulse may be not applied to the sensor element at an end face of the sensor element. The first current pulse may have a maximum between 40 and 1400 Ampere or between 60 and 800 Ampere or between 75 and 600 Ampere or between 80 and 500 Ampere. The current pulse may

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have a maximum such that an appropriate encoding is caused to the sensor element. However, due to different materials which may be used and different forms of the sensor element and different dimensions of the sensor element, a maximum of the current pulse may be adjusted in accordance with these parameters. The second pulse  
5 may have a similar maximum or may have a maximum approximately 10, 20, 30, 40 or 50 % smaller than the first maximum. However, the second pulse may also have a higher maximum such as 10, 20, 40, 50, 60 or 80 % higher than the first maximum.

A duration of those pulses may be the same. However, it is possible that the first  
10 pulse has a significant longer duration than the second pulse. However, it is also possible that the second pulse has a longer duration than the first pulse.

The first and/or second current pulses may have a first duration from the start of the pulse to the maximum and may have a second duration from the maximum to  
15 essentially the end of the pulse. The first duration may be significantly longer than the second duration. For example, the first duration may be smaller than 300 ms wherein the second duration may be larger than 300 ms. However, it is also possible that the first duration is smaller than 200 ms whereas the second duration is larger than 400 ms. Also, the first duration may be between 20 to 150 ms wherein the  
20 second duration may be between 180 to 700ms.

As already indicated above, it is possible to apply a plurality of first current pulses but also a plurality of second current pulses. The sensor element may be made of steel whereas the steel may comprise nickel. The sensor material used for the  
25 primary sensor or for the sensor element may be 50NiCr13 or X4CrNi13-4 or X5CrNiCuNb16-4 or X20CrNi17-4 or X46Cr13 or X20Cr13 or 14NiCr14 or S155 as set forth in DIN 1.2721 or 1.4313 or 1.4542 or 1.2787 or 1.4034 or 1.4021 or 1.5752 or 1.6928.

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The first current pulse may be applied by means of an electrode system having at least a first electrode and a second electrode. The first electrode is located at the first location or adjacent to the first location and the second electrode is located at the second location or adjacent to the second location.

Each of the first and second electrodes may have a plurality of electrode pins. The plurality of electrode pins of each of the first and second electrodes may be arranged circumferentially around the sensor element such that the sensor element is contacted by the electrode pins of the first and second electrodes at a plurality of contact points at an outer circumferential surface of the shaft at the first and second locations.

As indicated above, instead of electrode pins laminar or two-dimensional electrode surfaces may be applied. For instance, electrode surfaces are adapted to surfaces of the shaft such that a good contact between the electrodes and the shaft material may be ensured.

At least one of the first current pulse and at least one of the second current pulse may be applied to the sensor element such that the sensor element has a magnetically encoded region such that in a direction essentially perpendicular to a surface of the sensor element, the magnetically encoded region of the sensor element has a magnetic field structure such that there is a first magnetic flow in a first direction and a second magnetic flow in a second direction. The first direction may be opposite to the second direction.

In a cross-sectional view of the sensor element, there may be a first circular magnetic flow having the first direction and a first radius and a second circular magnetic flow



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having the second direction and a second radius. The first radius may be larger than the second radius.

Furthermore, the sensor elements may have a first pinning zone adjacent to the first  
5 location and a second pinning zone adjacent to the second location.

The pinning zones may be manufactured in accordance with the following manufacturing method. According to this method, for forming the first pinning zone, at the first location or adjacent to the first location, a third current pulse is applied on  
10 the circumferential surface of the sensor element such that there is a third current flow in the second direction. The third current flow is discharged from the sensor element at a third location which is displaced from the first location in the second direction.

15 For forming the second pinning zone, at the second location or adjacent to the second location, a forth current pulse may be applied on the circumferential surface to the sensor element such that there is a forth current flow in the first direction. The forth current flow is discharged at a forth location which is displaced from the second location in the first direction.

20 A torque sensor may be provided comprising a first sensor element with a magnetically encoded region wherein the first sensor element has a surface. In a direction essentially perpendicular to the surface of the first sensor element, the magnetically encoded region of the first sensor element may have a magnetic field  
25 structure such that there is a first magnetic flow in a first direction and a second magnetic flow in a second direction. The first and second directions may be opposite to each other.

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The torque sensor may further comprise a second sensor element with at least one magnetic field detector. The second sensor element may be adapted for detecting variations in the magnetically encoded region. More precisely, the second sensor element may be adapted for detecting variations in a magnetic field emitted from the magnetically encoded region of the first sensor element.

The magnetically encoded region may extend longitudinally along a section of the first sensor element, but does not extend from one end face of the first sensor element to the other end face of the first sensor element. In other words, the magnetically encoded region does not extend along all of the first sensor element but only along a section thereof.

The first sensor element may have variations in the material of the first sensor element caused by at least one current pulse or surge applied to the first sensor element for altering the magnetically encoded region or for generating the magnetically encoded region. Such variations in the material may be caused, for example, by differing contact resistances between electrode systems for applying the current pulses and the surface of the respective sensor element. Such variations may, for example, be burn marks or color variations or signs of an annealing.

The variations may be at an outer surface of the sensor element and not at the end faces of the first sensor element since the current pulses are applied to outer surface of the sensor element but not to the end faces thereof.

A shaft for a magnetic sensor may be provided having, in a cross-section thereof, at least two circular magnetic loops running in opposite direction. Such shaft is believed to be manufactured in accordance with the above-described manufacturing method.

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Furthermore, a shaft may be provided having at least two circular magnetic loops which are arranged concentrically.

- 5 A shaft for a torque sensor may be provided which is manufactured in accordance with the following manufacturing steps where firstly a first current pulse is applied to the shaft. The first current pulse is applied to the shaft such that there is a first current flow in a first direction along a longitudinal axis of the shaft. The first current pulse is such that the application of the current pulse generates a magnetically encoded  
10 region in the shaft. This may be made by using an electrode system as described above and by applying current pulses as described above.

- An electrode system may be provided for applying current surges to a sensor element for a torque sensor, the electrode system having at least a first electrode and a second  
15 electrode wherein the first electrode is adapted for location at a first location on an outer surface of the sensor element. A second electrode is adapted for location at a second location on the outer surface of the sensor element. The first and second electrodes are adapted for applying and discharging at least one current pulse at the first and second locations such that current flows within a core region of the sensor  
20 element are caused. The at least one current pulse is such that a magnetically encoded region is generated at a section of the sensor element.

- The electrode system may comprise at least two groups of electrodes, each comprising a plurality of electrode pins. The electrode pins of each electrode are  
25 arranged in a circle such that the sensor element is contacted by the electrode pins of the electrode at a plurality of contact points at an outer surface of the sensor element.

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The outer surface of the sensor element does not include the end faces of the sensor element.

Fig. 1 shows an exemplary embodiment of a torque sensor according to the present invention. The torque sensor comprises a first sensor element or shaft 2 having a rectangular cross-section. The first sensor element 2 extends essentially along the direction indicated with X. In a middle portion of the first sensor element 2, there is the encoded region 4. The first location is indicated by reference numeral 10 and indicates one end of the encoded region and the second location is indicated by reference numeral 12 which indicates another end of the encoded region or the region to be magnetically encoded 4. Arrows 14 and 16 indicate the application of a current pulse. As indicated in Fig. 1, a first current pulse is applied to the first sensor element 2 at an outer region adjacent or close to the first location 10. For instance, as will be described in further detail later on, the current is introduced into the first sensor element 2 at a plurality of points or regions close to the first location and surrounding the outer surface of the first sensor element 2 along the first location 10. As indicated with arrow 16, the current pulse is discharged from the first sensor element 2 close or adjacent or at the second location 12 for instance at a plurality or locations along the end of the region 4 to be encoded. As already indicated before, a plurality of current pulses may be applied in succession they may have alternating directions from location 10 to location 12 or from location 12 to location 10.

Reference numeral 6 indicates a second sensor element which is for instance a coil connected to a controller electronic 8. The controller electronic 8 may be adapted to further process a signal output by the second sensor element 6 such that an output signal may output from the control circuit corresponding to a torque applied to the first sensor element 2. The control circuit 8 may be an analog or digital circuit. The

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second sensor element 6 is adapted to detect a magnetic field emitted by the encoded region 4 of the first sensor element.

5 It is believed that, as already indicated above, if there is no stress or force applied to the first sensor element 2, there is essentially no field detected by the second sensor element 6. However, in case a stress or a force is applied to the secondary sensor element 2, there is a variation in the magnetic field emitted by the encoded region such that an increase of a magnetic field from the presence of almost no field is detected by the second sensor element 6.

10

It has to be noted that according to other exemplary embodiments of the present invention, even if there is no stress applied to the first sensor element, it may be possible that there is a magnetic field detectable outside or adjacent to the encoded region 4 of the first sensor element 2. However, it is to be noted that a stress applied  
15 to the first sensor element 2 causes a variation of the magnetic field emitted by the encoded region 4.

In the following, with reference to Figs. 2a, 2b, 3a, 3b and 4, a method of manufacturing a torque sensor according to an exemplary embodiment of the present  
20 invention will be described. In particular, the method relates to the magnetization of the magnetically encoded region 4 of the first sensor element 2.

As may be taken from Fig. 2a, a current I is applied to an end region of a region 4 to be magnetically encoded. This end region as already indicated above is indicated  
25 with reference numeral 10 and may be a circumferential region on the outer surface of the first sensor element 2. The current I is discharged from the first sensor element 2 at another end area of the magnetically encoded region (or of the region to be magnetically encoded) which is indicated by reference numeral 12 and also referred

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to a second location. The current is taken from the first sensor element at an outer surface thereof, for instance circumferentially in regions close or adjacent to location 12. As indicated by the dashed line between locations 10 and 12, the current I introduced at or along location 10 into the first sensor element flows through a core region or parallel to a core region to location 12. In other words, the current I flows through the region 4 to be encoded in the first sensor element 2.

Fig. 2b shows a cross-sectional view along AA'. In the schematic representation of Fig. 2b, the current flow is indicated into the plane of the Fig. 2b as a cross. Here, the current flow is indicated in a center portion of the cross-section of the first sensor element 2. It is believed that this introduction of a current pulse having a form as described above or in the following and having a maximum as described above or in the following causes a magnetic flow structure 20 in the cross-sectional view with a magnetic flow direction into one direction here into the clockwise direction. The magnetic flow structure 20 depicted in Fig. 2b is depicted essentially circular. However, the magnetic flow structure 20 may be adapted to the actual cross-section of the first sensor element 2 and may be, for example, more elliptical.

Figs. 3a and 3b show a step of the method according to an exemplary embodiment of the present invention which may be applied after the step depicted in Figs. 2a and 2b. Fig. 3a shows a first sensor element according to an exemplary embodiment of the present invention with the application of a second current pulse and Fig. 3b shows a cross-sectional view along BB' of the first sensor element 2.

As may be taken from Fig. 3a, in comparison to Fig. 2a, in Fig. 3a, the current I indicated by arrow 16 is introduced into the sensor element 2 at or adjacent to location 12 and is discharged or taken from the sensor element 2 at or adjacent to the location 10. In other words, the current is discharged in Fig. 3a at a location where it

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was introduced in Fig. 2a and vice versa. Thus, the introduction and discharging of the current I into the first sensor element 2 in Fig. 3a may cause a current through the region 4 to be magnetically encoded opposite to the respective current flow in Fig. 2a.

5

The current is indicated in Fig. 3b in a core region of the sensor element 2. As may be taken from a comparison of Figs. 2b and 3b, the magnetic flow structure 22 has a direction opposite to the current flow structure 20 in Fig. 2b.

- 10 As indicated before, the steps depicted in Figs. 2a, 2b and 3a and 3b may be applied individually or may be applied in succession of each other. When firstly, the step depicted in Figs. 2a and 2b is performed and then the step depicted in Figs. 3a and 3b, a magnetic flow structure as depicted in the cross-sectional view through the encoded region 4 depicted in Fig. 4 may be caused. As may be taken from Fig. 4, the
- 15 two current flow structures 20 and 22 are encoded into the encoded region together. Thus, in a direction essentially perpendicular to a surface of the first sensor element 2, in a direction to the core of the sensor element 2, there is a first magnetic flow having a first direction and then underlying there is a second magnetic flow having a second direction. As indicated in Fig. 4, the flow directions may be opposite to each
- 20 other.

- Thus, if there is no torque applied to the first torque sensor element 2, the two magnetic flow structures 20 and 22 may cancel each other such that there is essentially no magnetic field at the outside of the encoded region. However, in case a
- 25 stress or force is applied to the first sensor element 2, the magnetic field structures 20 and 22 cease to cancel each other such that there is a magnetic field occurring at the outside of the encoded region which may then be detected by means of the secondary sensor element 6. This will be described in further detail in the following.

- 40 -

- Fig. 5 shows another exemplary of a first sensor element 2 according to an exemplary embodiment of the present invention as may be used in a torque sensor according to an exemplary embodiment which is manufactured according to a manufacturing method according to an exemplary embodiment of the present invention. As may be taken from Fig. 5, the first sensor element 2 has an encoded region 4 which is for instance encoded in accordance with the steps and arrangements depicted in Figs. 2a, 2b, 3a, 3b and 4.
- 10 Adjacent to locations 10 and 12, there are provided pinning regions 42 and 44. These regions 42 and 44 are provided for avoiding a fraying of the encoded region 4. In other words, the pinning regions 42 and 44 may allow for a more definite beginning and end of the encoded region 4.
- 15 In short, the first pinning region 42 may be adapted by introducing a current 38 close or adjacent to the first location 10 into the first sensor element 2 in the same manner as described, for example, with reference to Fig. 2a. However, the current I is discharged from the first sensor element 2 at a first location 30 which is at a distance from the end of the encoded region close or at location 10. This further location is indicated by reference numeral 30. The introduction of this further current pulse I is indicated by arrow 38 and the discharging thereof is indicated by arrow 40. The current pulses may have the same form shaping maximum as described above.
- 20 For generating the second pinning region 44, a current is introduced into the first sensor element 2 at a location 32 which is at a distance from the end of the encoded region 4 close or adjacent to location 12. The current is then discharged from the first sensor element 2 at or close to the location 12. The introduction of the current pulse I is indicated by arrows 34 and 36.



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The pinning regions 42 and 44 may be such that the magnetic flow structures of these pinning regions 42 and 44 are opposite to the respective adjacent magnetic flow structures in the adjacent encoded region 4. As may be taken from Fig. 5, the pinning  
5 regions can be coded to the first sensor element 2 after the coding or the complete coding of the encoded region 4.

Fig. 6 shows another exemplary embodiment of the present invention where there is no encoding region 4. In other words, according to an exemplary embodiment of the  
10 present invention, the pinning regions may be coded into the first sensor element 2 before the actual coding of the magnetically encoded region 4.

Fig. 7 shows a simplified flow-chart of a method of manufacturing a first sensor element 2 for a torque sensor according to an exemplary embodiment of the present  
15 invention.

After the start in step S1, the method continues to step S2 where a first pulse is applied as described as reference to Figs. 2a and 2b. Then, after step S2, the method continues to step S3 where a second pulse is applied as described with reference to  
20 Figs. 3a and 3b.

Then, the method continues to step S4 where it is decided whether the pinning regions are to be coded to the first sensor element 2 or not. If it is decided in step S4 that there will be no pinning regions, the method continues directly to step S7 where  
25 it ends.

If it is decided in step S4 that the pinning regions are to be coded to the first sensor element 2, the method continues to step S5 where a third pulse is applied to the

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pinning region 42 in the direction indicated by arrows 38 and 40 and to pinning region 44 indicated by the arrows 34 and 36. Then, the method continues to step S6 where force pulses applied to the respective pinning regions 42 and 44. To the pinning region 42, a force pulse is applied having a direction opposite to the direction indicated by arrows 38 and 40. Also, to the pinning region 44, a force pulse is applied to the pinning region having a direction opposite to the arrows 34 and 36. Then, the method continues to step S7 where it ends.

In other words, for instance two pulses are applied for encoding of the magnetically encoded region 4. Those current pulses may have an opposite direction. Furthermore, two pulses respectively having respective directions are applied to the pinning region 42 and to the pinning region 44.

Fig. 8 shows a current versus time diagram of the pulses applied to the magnetically encoded region 4 and to the pinning regions. The positive direction of the y-axis of the diagram in Fig. 8 indicates a current flow into the x-direction and the negative direction of the y-axis of Fig. 8 indicates a current flow in the y-direction.

As may be taken from Fig. 8 for coding the magnetically encoded region 4, firstly a current pulse is applied having a direction into the x-direction. As may be taken from Fig. 8, the raising edge of the pulse is very sharp whereas the falling edge has a relatively long direction in comparison to the direction of the raising edge. As depicted in Fig. 8, the pulse may have a maximum of approximately 75 Ampere. In other applications, the pulse may be not as sharp as depicted in Fig. 8. However, the raising edge should be steeper or should have a shorter duration than the falling edge.

Then, a second pulse is applied to the encoded region 4 having an opposite direction. The pulse may have the same form as the first pulse. However, a maximum of the

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second pulse may also differ from the maximum of the first pulse. Although the immediate shape of the pulse may be different.

Then, for coding the pinning regions, pulses similar to the first and second pulse may  
5 be applied to the pinning regions as described with reference to Figs. 5 and 6. Such pulses may be applied to the pinning regions simultaneously but also successfully for each pinning region. As depicted in Fig. 8, the pulses may have essentially the same form as the first and second pulses. However, a maximum may be smaller.

10 Fig. 9 shows another exemplary embodiment of a first sensor element of a torque sensor according to an exemplary embodiment of the present invention showing an electrode arrangement for applying the current pulses for coding the magnetically encoded region 4. As may be taken from Fig. 9, a conductor without an isolation may be looped around the first sensor element 2 which is may be taken from Fig. 9 may  
15 be a circular shaft having a circular cross-section. For ensuring a close fit of the conductor on the outer surface of the first sensor element 2, the conductor may be clamped as shown by arrows 64.

Fig. 10a shows another exemplary embodiment of a first sensor element according to  
20 an exemplary embodiment of the present invention. Furthermore, Fig. 10a shows another exemplary embodiment of an electrode system according to an exemplary embodiment of the present invention. The electrode system 80 and 82 depicted in Fig. 10a contacts the first sensor element 2 which has a triangular cross-section with two contact points at each phase of the triangular first sensor element at each side of  
25 the region 4 which is to be encoded as magnetically encoded region. Overall, there are six contact points at each side of the region 4. The individual contact points may be connected to each other and then connected to one individual contact points.

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If there is only a limited number of contact points between the electrode system and the first sensor element 2 and if the current pulses applied are very high, differing contact resistances between the contacts of the electrode systems and the material of the first sensor element 2 may cause burn marks at the first sensor element 2 at contact point to the electrode systems. These burn marks 90 may be color changes, may be welding spots, may be annealed areas or may simply be burn marks. According to an exemplary embodiment of the present invention, the number of contact points is increased or even a contact surface is provided such that such burn marks 90 may be avoided.

10

Fig. 11 shows another exemplary embodiment of a first sensor element 2 which is a shaft having a circular cross-section according to an exemplary embodiment of the present invention. As may be taken from Fig. 11, the magnetically encoded region is at an end region of the first sensor element 2. According to an exemplary embodiment of the present invention, the magnetically encoded region 4 is not extend over the full length of the first sensor element 2. As may be taken from Fig. 11, it may be located at one end thereof. However, it has to be noted that according to an exemplary embodiment of the present invention, the current pulses are applied from an outer circumferential surface of the first sensor element 2 and not from the end face 100 of the first sensor element 2.

20

In the following, the so-called PCME ("Pulse-Current-Modulated Encoding") Sensing Technology will be described in detail, which can, according to an exemplary embodiment of the invention, be implemented to magnetize a magnetizable object which is then partially demagnetized according to the invention. In the following, the PCME technology will partly described in the context of torque sensing. However, this concept may implemented in the context of position sensing as well.

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- 45 -

In this description, there are a number of acronyms used as otherwise some explanations and descriptions may be difficult to read. While the acronyms "ASIC", "IC", and "PCB" are already market standard definitions, there are many terms that are particularly related to the magnetostriction based NCT sensing technology. It should be noted that in this description, when there is a reference to NCT technology or to PCME, it is referred to exemplary embodiments of the present invention.

Table 1 shows a list of abbreviations used in the following description of the PCME technology.

	Acronym	Description	Category
	ASIC	Application Specific IC	Electronics
	DF	Dual Field	Primary Sensor
15	EMF	Earth Magnetic Field	Test Criteria
	FS	Full Scale	Test Criteria
	Hot-Spotting	Sensitivity to nearby Ferro magnetic material	Specification
	IC	Integrated Circuit	Electronics
	MFS	Magnetic Field Sensor	Sensor
20	Component		
	NCT	Non Contact Torque	Technology
	PCB	Printed Circuit Board	Electronics
	PCME	Pulse Current Modulated Encoding	Technology
	POC	Proof-of-Concept	
25	RSU	Rotational Signal Uniformity	Specification
	SCSP	Signal Conditioning & Signal Processing	Electronics
	SF	Single Field	Primary Sensor
	SH	Sensor Host	Primary Sensor

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SPHC	Shaft Processing Holding Clamp	Processing Tool
SSU	Secondary Sensor Unit	Sensor Component

Table 1: List of abbreviations

5

- The magnetic principle based mechanical-stress sensing technology allows to design and to produce a wide range of “physical-parameter-sensors” (like Force Sensing, Torque Sensing, and Material Diagnostic Analysis) that can be applied where Ferro-
- 10 Magnetic materials are used. The most common technologies used to build “magnetic-principle-based” sensors are: Inductive differential displacement measurement (requires torsion shaft), measuring the changes of the materials permeability, and measuring the magnetostriction effects.
- 15 Over the last 20 years a number of different companies have developed their own and very specific solution in how to design and how to produce a magnetic principle based torque sensor (i.e. ABB, FAST, Fraunhofer Institute, FT, Kubota, MDI, NCTE, RM, Siemens, and others). These technologies are at various development stages and differ in “how-it-works”, the achievable performance, the systems
- 20 reliability, and the manufacturing / system cost.

- Some of these technologies require that mechanical changes are made to the shaft where torque should be measured (chevrons), or rely on the mechanical torsion effect (require a long shaft that twists under torque), or that something will be attached to
- 25 the shaft itself (press-fitting a ring of certain properties to the shaft surface,), or coating of the shaft surface with a special substance. No-one has yet mastered a high-volume manufacturing process that can be applied to (almost) any shaft size,

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achieving tight performance tolerances, and is not based on already existing technology patents.

5 In the following, a magnetostriction principle based Non-Contact-Torque (NCT) Sensing Technology is described that offers to the user a whole host of new features and improved performances, previously not available. This technology enables the realization of a fully-integrated (small in space), real-time (high signal bandwidth) torque measurement, which is reliable and can be produced at an affordable cost, at any desired quantities. This technology is called: PCME (for Pulse-Current-Modulated Encoding) or Magnetostriction Transversal Torque Sensor.

10

The PCME technology can be applied to the shaft without making any mechanical changes to the shaft, or without attaching anything to the shaft. Most important, the PCME technology can be applied to any shaft diameter (most other technologies have here a limitation) and does not need to rotate / spin the shaft during the  
15 encoding process (very simple and low-cost manufacturing process) which makes this technology very applicable for high-volume application.

In the following, a Magnetic Field Structure (Sensor Principle) will be described.

20 The sensor life-time depends on a "closed-loop" magnetic field design. The PCME technology is based on two magnetic field structures, stored above each other, and running in opposite directions. When no torque stress or motion stress is applied to the shaft (also called Sensor Host, or SH) then the SH will act magnetically neutral (no magnetic field can be sensed at the outside of the SH).

25

Fig.12 shows that two magnetic fields are stored in the shaft and running in endless circles. The outer field runs in one direction, while the inner field runs in the opposite direction.

**Fig.13** illustrates that the PCME sensing technology uses two Counter-Circular magnetic field loops that are stored on top of each other (Picky-Back mode).

When mechanical stress (like reciprocation motion or torque) is applied at both ends  
5 of the PCME magnetized SH (Sensor Host, or Shaft) then the magnetic flux lines of both magnetic structures (or loops) will tilt in proportion to the applied torque.

As illustrated in **Fig.14**, when no mechanical stresses are applied to the SH the magnetic flux lines are running in its original path. When mechanical stresses are  
10 applied the magnetic flux lines tilt in proportion to the applied stress (like linear motion or torque).

Depending on the applied torque direction (clockwise or anti-clockwise, in relation to the SH) the magnetic flux lines will either tilt to the right or tilt to the left. Where  
15 the magnetic flux lines reach the boundary of the magnetically encoded region, the magnetic flux lines from the upper layer will join-up with the magnetic flux lines from the lower layer and visa-versa. This will then form a perfectly controlled toroidal shape.

20 The benefits of such a magnetic structure are:

- ☐ Reduced (almost eliminated) parasitic magnetic field structures when mechanical stress is applied to the SH (this will result in better RSU performances).
- ☐ Higher Sensor-Output Signal-Slope as there are two “active” layers that  
25 compliment each other when generating a mechanical stress related signal.  
Explanation: When using a single-layer sensor design, the “tilted” magnetic flux lines that exit at the encoding region boundary have to create a “return passage” from one boundary side to the other. This effort effects how much



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signal is available to be sensed and measured outside of the SH with the secondary sensor unit.

- ☐ There are almost no limitations on the SH (shaft) dimensions where the PCME technology will be applied to. The dual layered magnetic field structure can be adapted to any solid or hollow shaft dimensions.
- ☐ The physical dimensions and sensor performances are in a very wide range programmable and therefore can be tailored to the targeted application.
- ☐ This sensor design allows to measure mechanical stresses coming from all three dimensions axis, including in-line forces applied to the shaft (applicable as a load-cell). Explanation: Earlier magnetostriction sensor designs (for example from FAST Technology) have been limited to be sensitive in 2 dimensional axis only, and could not measure in-line forces.

Referring to Fig.15, when torque is applied to the SH, the magnetic flux lines from both Counter-Circular magnetic loops are connecting to each other at the sensor region boundaries.

When mechanical torque stress is applied to the SH then the magnetic field will no longer run around in circles but tilt slightly in proportion to the applied torque stress. This will cause the magnetic field lines from one layer to connect to the magnetic field lines in the other layer, and with this form a toroidal shape.

Referring to Fig.16, an exaggerated presentation is shown of how the magnetic flux line will form an angled toroidal structure when high levels of torque are applied to the SH.

In the following, features and benefits of the PCM-Encoding (PCME) Process will be described.

- 50 -

The magnetostriction NCT sensing technology from NCTE according to the present invention offers high performance sensing features like:

- 5        ☐ No mechanical changes required on the Sensor Host (already existing shafts can be used as they are)
- ☐ Nothing has to be attached to the Sensor Host (therefore nothing can fall off or change over the shaft-lifetime = high MTBF)
- ☐ During measurement the SH can rotate, reciprocate or move at any desired
- 10       speed (no limitations on rpm)
- ☐ Very good RSU (Rotational Signal Uniformity) performances
- ☐ Excellent measurement linearity (up to 0.01% of FS)
- ☐ High measurement repeatability
- ☐ Very high signal resolution (better than 14 bit)
- 15       ☐ Very high signal bandwidth (better than 10 kHz)

Depending on the chosen type of magnetostriction sensing technology, and the chosen physical sensor design, the mechanical power transmitting shaft (also called "Sensor Host" or in short "SH") can be used "as is" without making any mechanical

20 changes to it or without attaching anything to the shaft. This is then called a "true" Non-Contact-Torque measurement principle allowing the shaft to rotate freely at any desired speed in both directions.

The here described PCM-Encoding (PCME) manufacturing process according to an

25 exemplary embodiment of the present invention provides additional features no other magnetostriction technology can offer (Uniqueness of this technology):

- 51. -

- ☐ More than three times signal strength in comparison to alternative magnetostriction encoding processes (like the "RS" process from FAST).
- ☐ Easy and simple shaft loading process (high manufacturing through-put).
- ☐ No moving components during magnetic encoding process (low complexity manufacturing equipment = high MTBF, and lower cost).
- ☐ Process allows NCT sensor to be "fine-tuning" to achieve target accuracy of a fraction of one percent.
- ☐ Manufacturing process allows shaft "pre-processing" and "post-processing" in the same process cycle (high manufacturing through-put).
- ☐ Sensing technology and manufacturing process is ratio-metric and therefore is applicable to all shaft or tube diameters.
- ☐ The PCM-Encoding process can be applied while the SH is already assembled (depending on accessibility) (maintenance friendly).
- ☐ Final sensor is insensitive to axial shaft movements (the actual allowable axial shaft movement depends on the physical "length" of the magnetically encoded region).
- ☐ Magnetically encoded SH remains neutral and has little to non magnetic field when no forces (like torque) are applied to the SH.
- ☐ Sensitive to mechanical forces in all three dimensional axis.

In the following, the Magnetic Flux Distribution in the SH will be described.

The PCME processing technology is based on using electrical currents, passing through the SH (Sensor Host or Shaft) to achieve the desired, permanent magnetic encoding of the Ferro-magnetic material. To achieve the desired sensor performance and features a very specific and well controlled electrical current is required. Early experiments that used DC currents failed because of lack of understanding how small amounts and large amounts of DC electric current are travelling through a conductor

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(in this case the “conductor” is the mechanical power transmitting shaft, also called Sensor Host or in short “SH”).

Referring to Fig.17, an assumed electrical current density in a conductor is  
5 illustrated.

It is widely assumed that the electric current density in a conductor is evenly distributed over the entire cross-section of the conductor when an electric current (DC) passes through the conductor.

10

Referring to Fig.18, a small electrical current forming magnetic field that ties current path in a conductor is shown.

It is our experience that when a small amount of electrical current (DC) is passing  
15 through the conductor that the current density is highest at the centre of the conductor. The two main reasons for this are: The electric current passing through a conductor generates a magnetic field that is tying together the current path in the centre of the conductor, and the impedance is the lowest in the centre of the conductor.

20

Referring to Fig.19, a typical flow of small electrical currents in a conductor is illustrated.

In reality, however, the electric current may not flow in a “straight” line from one  
25 connection pole to the other (similar to the shape of electric lightening in the sky).

At a certain level of electric current the generated magnetic field is large enough to cause a permanent magnetization of the Ferro-magnetic shaft material. As the

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electric current is flowing near or at the centre of the SH, the permanently stored magnetic field will reside at the same location: near or at the centre of the SH. When now applying mechanical torque or linear force for oscillation/reciprocation to the shaft, then shaft internally stored magnetic field will respond by tilting its magnetic  
5 flux path in accordance to the applied mechanical force. As the permanently stored magnetic field lies deep below the shaft surface the measurable effects are very small, not uniform and therefore not sufficient to build a reliable NCT sensor system.

Referring to Fig.20, a uniform current density in a conductor at saturation level is  
10 shown.

Only at the saturation level is the electric current density (when applying DC) evenly distributed at the entire cross section of the conductor. The amount of electrical current to achieve this saturation level is extremely high and is mainly influenced by  
15 the cross section and conductivity (impedance) of the used conductor.

Referring to Fig.21, electric current travelling beneath or at the surface of the conductor (Skin-Effect) is shown.

20 It is also widely assumed that when passing through alternating current (like a radio frequency signal) through a conductor that the signal is passing through the skin layers of the conductor, called the Skin Effect. The chosen frequency of the alternating current defines the "Location / position" and "depth" of the Skin Effect. At high frequencies the electrical current will travel right at or near the surface of the  
25 conductor (A) while at lower frequencies (in the 5 to 10 Hz regions for a 20 mm diameter SH) the electrical alternating current will penetrate more the centre of the shafts cross section (E). Also, the relative current density is higher in the current occupied regions at higher AC frequencies in comparison to the relative current

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density near the centre of the shaft at very low AC frequencies (as there is more space available for the current to flow through).

Referring to Fig.22, the electrical current density of an electrical conductor (cross-section 90 deg to the current flow) when passing through the conductor an alternating  
5 current at different frequencies is illustrated.

The desired magnetic field design of the PCME sensor technology are two circular magnetic field structures, stored in two layers on top of each other ("Picky-Back"),  
10 and running in opposite direction to each other (Counter-Circular).

Again referring to Fig.13, a desired magnetic sensor structure is shown: two endless magnetic loops placed on top of each other, running in opposite directions to each other: Counter-Circular "Picky-Back" Field Design.  
15

To make this magnetic field design highly sensitive to mechanical stresses that will be applied to the SH (shaft), and to generate the largest sensor signal possible, the desired magnetic field structure has to be placed nearest to the shaft surface. Placing the circular magnetic fields to close to the centre of the SH will cause damping of the  
20 user available sensor-output-signal slope (most of the sensor signal will travel through the Ferro-magnetic shaft material as it has a much higher permeability in comparison to air), and increases the non-uniformity of the sensor signal (in relation to shaft rotation and to axial movements of the shaft in relation to the secondary sensor.

25 Referring to Fig.23, magnetic field structures stored near the shaft surface and stored near the centre of the shaft are illustrated.

- 55 -

It may be difficult to achieve the desired permanent magnetic encoding of the SH when using AC (alternating current) as the polarity of the created magnetic field is constantly changing and therefore may act more as a Degaussing system.

- 5     The PCME technology requires that a strong electrical current (“uni-polar” or DC, to prevent erasing of the desired magnetic field structure) is travelling right below the shaft surface (to ensure that the sensor signal will be uniform and measurable at the outside of the shaft). In addition a Counter-Circular, “picky back” magnetic field structure needs to be formed.

10

It is possible to place the two Counter-Circular magnetic field structures in the shaft by storing them into the shaft one after each other. First the inner layer will be stored in the SH, and then the outer layer by using a weaker magnetic force (preventing that the inner layer will be neutralized and deleted by accident. To achieve this, the  
15     known “permanent” magnet encoding techniques can be applied as described in patents from FAST technology, or by using a combination of electrical current encoding and the “permanent” magnet encoding.

- 20     A much simpler and faster encoding process uses “only” electric current to achieve the desired Counter-Circular “Picky-Back” magnetic field structure. The most challenging part here is to generate the Counter-Circular magnetic field.

A uniform electrical current will produce a uniform magnetic field, running around the electrical conductor in a 90 deg angle, in relation to the current direction (A).

- 25     When placing two conductors side-by-side (B) then the magnetic field between the two conductors seems to cancel-out the effect of each other (C). Although still present, there is no detectable (or measurable) magnetic field between the closely placed two conductors. When placing a number of electrical conductors side-by-side

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(D) the “measurable” magnetic field seems to go around the outside the surface of the “flat” shaped conductor.

Referring to Fig.24, the magnetic effects when looking at the cross-section of a  
5 conductor with a uniform current flowing through them are shown.

The “flat” or rectangle shaped conductor has now been bent into a “U”-shape. When passing an electrical current through the “U”-shaped conductor then the magnetic field following the outer dimensions of the “U”-shape is cancelling out the  
10 measurable effects in the inner halve of the “U”.

Referring to Fig.25, the zone inside the “U”-shaped conductor seem to be magnetically “Neutral” when an electrical current is flowing through the conductor.

15 When no mechanical stress is applied to the cross-section of a “U”-shaped conductor it seems that there is no magnetic field present inside of the “U” (F). But when bending or twisting the “U”-shaped conductor the magnetic field will no longer follow its original path (90 deg angle to the current flow). Depending on the applied mechanical forces, the magnetic field begins to change slightly its path. At that time  
20 the magnetic-field-vector that is caused by the mechanical stress can be sensed and measured at the surface of the conductor, inside and outside of the “U”-shape. Note: This phenomena is applies only at very specific electrical current levels.

The same applies to the “O”-shaped conductor design. When passing a uniform  
25 electrical current through an “O”-shaped conductor (Tube) the measurable magnetic effects inside of the “O” (Tube) have cancelled-out each other (G).



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Referring to Fig.26, the zone inside the "O"-shaped conductor seem to be magnetically "Neutral" when an electrical current is flowing through the conductor.

5 However, when mechanical stresses are applied to the "O"-shaped conductor (Tube) it becomes evident that there has been a magnetic field present at the inner side of the "O"-shaped conductor. The inner, counter directional magnetic field (as well as the outer magnetic field) begins to tilt in relation to the applied torque stresses. This tilting field can be clearly sensed and measured.

10 In the following, an Encoding Pulse Design will be described.

To achieve the desired magnetic field structure (Counter-Circular, Picky-Back, Fields Design) inside the SH, according to an exemplary embodiment of a method of the present invention, unipolar electrical current pulses are passed through the Shaft  
15 (or SH). By using "pulses" the desired "Skin-Effect" can be achieved. By using a "unipolar" current direction (not changing the direction of the electrical current) the generated magnetic effect will not be erased accidentally.

The used current pulse shape is most critical to achieve the desired PCME sensor  
20 design. Each parameter has to be accurately and repeatable controlled: Current raising time, Constant current on-time, Maximal current amplitude, and Current falling time. In addition it is very critical that the current enters and exits very uniformly around the entire shaft surface.

25 In the following, a Rectangle Current Pulse Shape will be described.

Referring to Fig.27, a rectangle shaped electrical current pulse is illustrated.

A rectangle shaped current pulse has a fast raising positive edge and a fast falling current edge. When passing a rectangle shaped current pulse through the SH, the raising edge is responsible for forming the targeted magnetic structure of the PCME sensor while the flat "on" time and the falling edge of the rectangle shaped current pulse are counter productive.

Referring to Fig.28, a relationship between rectangles shaped Current Encoding Pulse-Width (Constant Current On-Time) and Sensor Output Signal Slope is shown.

10 In the following example a rectangle shaped current pulse has been used to generate and store the Counter-Circular "Picky-Back" field in a 15 mm diameter, 14CrNi14 shaft. The pulsed electric current had its maximum at around 270 Ampere. The pulse "on-time" has been electronically controlled. Because of the high frequency component in the rising and falling edge of the encoding pulse, this experiment can not truly represent the effects of a true DC encoding SH. Therefore the Sensor-  
15 Output-Signal Slope-curve eventually flattens-out at above 20 mV/Nm when passing the Constant-Current On-Time of 1000 ms.

Without using a fast raising current-pulse edge (like using a controlled ramping  
20 slope) the sensor output signal slope would have been very poor (below 10 mV/Nm). Note: In this experiment (using 14CrNi14) the signal hysteresis was around 0.95% of the FS signal (FS = 75 Nm torque).

Referring to Fig.29, increasing the Sensor-Output Signal-Slope by using several  
25 rectangle shaped current pulses in succession is shown.

The Sensor-Output-Signal slope can be improved when using several rectangle shaped current-encoding-pulses in successions. In comparisons to other encoding-

pulse-shapes the fast falling current-pulse signal slope of the rectangle shaped current pulse will prevent that the Sensor-Output-Signal slope may ever reach an optimal performance level. Meaning that after only a few current pulses (2 to 10) have been applied to the SH (or Shaft) the Sensor-Output Signal-Slope will no longer rise.

5

In the following, a Discharge Current Pulse Shape is described.

The Discharge-Current-Pulse has no Constant-Current ON-Time and has no fast falling edge. Therefore the primary and most felt effect in the magnetic encoding of the SH is the fast raising edge of this current pulse type.

10

As shown in Fig.30, a sharp raising current edge and a typical discharging curve provides best results when creating a PCME sensor.

15 Referring to Fig.31, a PCME Sensor-Output Signal-Slope optimization by identifying the right pulse current is illustrated.

At the very low end of the pulse current scale (0 to 75 A for a 15 mm diameter shaft, 14CrNi14 shaft material) the "Discharge-Current-Pulse type is not powerful enough to cross the magnetic threshold needed to create a lasting magnetic field inside the Ferro magnetic shaft. When increasing the pulse current amplitude the double circular magnetic field structure begins to form below the shaft surface. As the pulse current amplitude increases so does the achievable torque sensor-output signal-amplitude of the secondary sensor system. At around 400A to 425A the optimal PCME sensor design has been achieved (the two counter flowing magnetic regions have reached their most optimal distance to each other and the correct flux density for best sensor performances.

20

25

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Referring to Fig.32, Sensor Host (SH) cross section with the optimal PCME electrical current density and location during the encoding pulse is illustrated.

When increasing further the pulse current amplitude the absolute, torque force  
5 related, sensor signal amplitude will further increase (curve 2) for some time while the overall PCME-typical sensor performances will decrease (curve 1). When passing 900A Pulse Current Amplitude (for a 15 mm diameter shaft) the absolute, torque force related, sensor signal amplitude will begin to drop as well (curve 2) while the PCME sensor performances are now very poor (curve 1).

10

Referring to Fig.33, Sensor Host (SH) cross sections and the electrical pulse current density at different and increasing pulse current levels is shown.

As the electrical current occupies a larger cross section in the SH the spacing  
15 between the inner circular region and the outer (near the shaft surface) circular region becomes larger.

Referring to Fig.34, better PCME sensor performances will be achieved when the spacing between the Counter-Circular "Picky-Back" Field design is narrow (A).

20

The desired double, counter flow, circular magnetic field structure will be less able to create a close loop structure under torque forces which results in a decreasing secondary sensor signal amplitude.

25 Referring to Fig.35, flattening-out the current-discharge curve will also increase the Sensor-Output Signal-Slope.

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When increasing the Current-Pulse discharge time (making the current pulse wider) (B) the Sensor-Output Signal-Slope will increase. However the required amount of current is very high to reduce the slope of the falling edge of the current pulse. It might be more practical to use a combination of a high current amplitude (with the optimal value) and the slowest possible discharge time to achieve the highest possible Sensor-Output Signal Slope.

In the following, Electrical Connection Devices in the frame of Primary Sensor Processing will be described.

10

The PCME technology (it has to be noted that the term 'PCME' technology is used to refer to exemplary embodiments of the present invention) relies on passing through the shaft very high amounts of pulse-modulated electrical current at the location where the Primary Sensor should be produced. When the surface of the shaft is very clean and highly conductive a multi-point Copper or Gold connection may be sufficient to achieve the desired sensor signal uniformity. Important is that the Impedance is identical of each connection point to the shaft surface. This can be best achieved when assuring the cable length (L) is identical before it joins the main current connection point (I).

20

Referring to Fig.36, a simple electrical multi-point connection to the shaft surface is illustrated.

However, in most cases a reliable and repeatable multi-point electrical connection can be only achieved by ensuring that the impedance at each connection point is identical and constant. Using a spring pushed, sharpened connector will penetrate possible oxidation or isolation layers (maybe caused by finger prints) at the shaft surface.

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Referring to Fig.37, a multi channel, electrical connecting fixture, with spring loaded contact points is illustrated.

- 5 When processing the shaft it is most important that the electrical current is injected and extracted from the shaft in the most uniform way possible. The above drawing shows several electrical, from each other insulated, connectors that are held by a fixture around the shaft. This device is called a Shaft-Processing-Holding-Clamp (or SPHC). The number of electrical connectors required in a SPHC depends on the
- 10 shafts outer diameter. The larger the outer diameter, the more connectors are required. The spacing between the electrical conductors has to be identical from one connecting point to the next connecting point. This method is called Symmetrical-“Spot”-Contacts.
- 15 Referring to Fig.38, it is illustrated that increasing the number of electrical connection points will assist the efforts of entering and exiting the Pulse-Modulated electrical current. It will also increase the complexity of the required electronic control system.
- 20 Referring to Fig.39, an example of how to open the SPHC for easy shaft loading is shown.

In the following, an encoding scheme in the frame of Primary Sensor Processing will be described.

25

The encoding of the primary shaft can be done by using permanent magnets applied at a rotating shaft or using electric currents passing through the desired section of the shaft. When using permanent magnets a very complex, sequential procedure is

necessary to put the two layers of closed loop magnetic fields, on top of each other, in the shaft. When using the PCME procedure the electric current has to enter the shaft and exit the shaft in the most symmetrical way possible to achieve the desired performances.

5

Referring to Fig.40, two SPHCs (Shaft Processing Holding Clamps) are placed at the borders of the planned sensing encoding region. Through one SPHC the pulsed electrical current (I) will enter the shaft, while at the second SPHC the pulsed electrical current (I) will exit the shaft. The region between the two SPHCs will then  
10 turn into the primary sensor.

This particular sensor process will produce a Single Field (SF) encoded region. One benefit of this design (in comparison to those that are described below) is that this design is insensitive to any axial shaft movements in relation to the location of the  
15 secondary sensor devices. The disadvantage of this design is that when using axial (or in-line) placed MFS coils the system will be sensitive to magnetic stray fields (like the earth magnetic field).

Referring to Fig.41, a Dual Field (DF) encoded region (meaning two independent  
20 functioning sensor regions with opposite polarity, side-by-side) allows cancelling the effects of uniform magnetic stray fields when using axial (or in-line) placed MFS coils. However, this primary sensor design also shortens the tolerable range of shaft movement in axial direction (in relation to the location of the MFS coils). There are two ways to produce a Dual Field (DF) encoded region with the PCME technology.  
25 The sequential process, where the magnetic encoded sections are produced one after each other, and the parallel process, where both magnetic encoded sections are produced at the same time.

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The first process step of the sequential dual field design is to magnetically encode one sensor section (identically to the Single Field procedure), whereby the spacing between the two SPHC has to be half of the desired final length of the Primary Sensor region. To simplify the explanations of this process we call the SPHC that is placed in the centre of the final Primary Sensor Region the Centre SPHC (C-SPHC), and the SPHC that is located at the left side of the Centre SPHC: L-SPHC.

Referring to Fig.42, the second process step of the sequential Dual Field encoding will use the SPHC that is located in the centre of the Primary Sensor region (called C-SPHC) and a second SPHC that is placed at the other side (the right side) of the centre SPHC, called R-SPHC. Important is that the current flow direction in the centre SPHC (C-SPHC) is identical at both process steps.

Referring to Fig.43, the performance of the final Primary Sensor Region depends on how close the two encoded regions can be placed in relation to each other. And this is dependent on the design of the used centre SPHC. The narrower the in-line space contact dimensions are of the C-SPHC, the better are the performances of the Dual Field PCME sensor.

Fig.44 shows the pulse application according to another exemplary embodiment of the present invention. As may be taken from the above drawing, the pulse is applied to three locations of the shaft. Due to the current distribution to both sides of the middle electrode where the current  $I$  is entered into the shaft, the current leaving the shaft at the lateral electrodes is only half the current entered at the middle electrode, namely  $\frac{1}{2} I$ . The electrodes are depicted as rings which dimensions are adapted to the dimensions of the outer surface of the shaft. However, it has to be noted that other electrodes may be used, such as the electrodes comprising a plurality of pin electrodes described later in this text.



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Referring to Fig.45, magnetic flux directions of the two sensor sections of a Dual Field PCME sensor design are shown when no torque or linear motion stress is applied to the shaft. The counter flow magnetic flux loops do not interact with each other.

Referring to Fig.46, when torque forces or linear stress forces are applied in a particular direction then the magnetic flux loops begin to run with an increasing tilting angle inside the shaft. When the tilted magnetic flux reaches the PCME segment boundary then the flux line interacts with the counterflowing magnetic flux lines, as shown.

Referring to Fig.47, when the applied torque direction is changing (for example from clock-wise to counter-clock-wise) so will change the tilting angle of the counterflow magnetic flux structures inside the PCM Encoded shaft.

In the following, a Multi Channel Current Driver for Shaft Processing will be described.

In cases where an absolute identical impedance of the current path to the shaft surface can not be guaranteed, then electric current controlled driver stages can be used to overcome this problem.

Referring to Fig.48, a six-channel synchronized Pulse current driver system for small diameter Sensor Hosts (SH) is shown. As the shaft diameter increases so will the number of current driver channels.

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In the following, Bras Ring Contacts and Symmetrical "Spot" Contacts will be described.

- 5    When the shaft diameter is relative small and the shaft surface is clean and free from any oxidations at the desired Sensing Region, then a simple "Bras"-ring (or Copper-ring) contact method can be chosen to process the Primary Sensor.

- Referring to Fig.49, bras-rings (or Copper-rings) tightly fitted to the shaft surface  
10   may be used, with solder connections for the electrical wires. The area between the two Bras-rings (Copper-rings) is the encoded region.

However, it is very likely that the achievable RSU performances are much lower then when using the Symmetrical "Spot" Contact method.

15

In the following, a Hot-Spotting concept will be described.

- A standard single field (SF) PCME sensor has very poor Hot-Spotting performances. The external magnetic flux profile of the SF PCME sensor segment (when torque is  
20   applied) is very sensitive to possible changes (in relation to Ferro magnetic material) in the nearby environment. As the magnetic boundaries of the SF encoded sensor segment are not well defined (not "Pinned Down") they can "extend" towards the direction where Ferro magnet material is placed near the PCME sensing region.

- 25   Referring to Fig.50, a PCME process magnetized sensing region is very sensitive to Ferro magnetic materials that may come close to the boundaries of the sensing regions.

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To reduce the Hot-Spotting sensor sensitivity the PCME sensor segment boundaries have to be better defined by pinning them down (they can no longer move).

Referring to Fig.51, a PCME processed Sensing region with two "Pinning Field  
5 Regions" is shown, one on each side of the Sensing Region.

By placing Pinning Regions closely on either side the Sensing Region, the Sensing Region Boundary has been pinned down to a very specific location. When Ferro magnetic material is coming close to the Sensing Region, it may have an effect on  
10 the outer boundaries of the Pinning Regions, but it will have very limited effects on the Sensing Region Boundaries.

There are a number of different ways, according to exemplary embodiments of the present invention how the SH (Sensor Host) can be processed to get a Single Field  
15 (SF) Sensing Region and two Pinning Regions, one on each side of the Sensing Region. Either each region is processed after each other (Sequential Processing) or two or three regions are processed simultaneously (Parallel Processing). The Parallel Processing provides a more uniform sensor (reduced parasitic fields) but requires much higher levels of electrical current to get to the targeted sensor signal slope.

20

Referring to Fig.52, a parallel processing example for a Single Field (SF) PCME sensor with Pinning Regions on either side of the main sensing region is illustrated, in order to reduce (or even eliminate) Hot-Spotting.

25 A Dual Field PCME Sensor is less sensitive to the effects of Hot-Spotting as the sensor centre region is already Pinned-Down. However, the remaining Hot-Spotting sensitivity can be further reduced by placing Pinning Regions on either side of the Dual-Field Sensor Region.

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Referring to Fig.53, a Dual Field (DF) PCME sensor with Pinning Regions either side is shown.

- 5 When Pinning Regions are not allowed or possible (example: limited axial spacing available) then the Sensing Region has to be magnetically shielded from the influences of external Ferro Magnetic Materials.

In the following, the Rotational Signal Uniformity (RSU) will be explained.

10

The RSU sensor performance are, according to current understanding, mainly depending on how circumferentially uniform the electrical current entered and exited the SH surface, and the physical space between the electrical current entry and exit points. The larger the spacing between the current entry and exit points, the better is the RSU performance.

15

Referring to Fig.54, when the spacings between the individual circumferential placed current entry points are relatively large in relation to the shaft diameter (and equally large are the spacings between the circumferentially placed current exit points) then this will result in very poor RSU performances. In such a case the length of the PCM Encoding Segment has to be as large as possible as otherwise the created magnetic field will be circumferentially non-uniform.

20

Referring to Fig.55, by widening the PCM Encoding Segment the circumferentially magnetic field distribution will become more uniform (and eventually almost perfect) at the halve distance between the current entry and current exit points. Therefore the RSU performance of the PCME sensor is best at the halve way-point between of the current-entry / current-exit points.

25

Next, the basic design issues of a NCT sensor system will be described.

Without going into the specific details of the PCM-Encoding technology, the end-  
5 user of this sensing technology need to know some design details that will allow him  
to apply and to use this sensing concept in his application. The following pages  
describe the basic elements of a magnetostriction based NCT sensor (like the primary  
sensor, secondary sensor, and the SCSP electronics), what the individual components  
look like, and what choices need to be made when integrating this technology into an  
10 already existing product.

In principle the PCME sensing technology can be used to produce a stand-alone  
sensor product. However, in already existing industrial applications there is little to  
none space available for a "stand-alone" product. The PCME technology can be  
15 applied in an existing product without the need of redesigning the final product.

In case a stand-alone torque sensor device or position detecting sensor device will be  
applied to a motor-transmission system it may require that the entire system need to  
undergo a major design change.

20

In the following, referring to Fig.56, a possible location of a PCME sensor at the  
shaft of an engine is illustrated.

Fig. 56 shows possible arrangement locations for the torque sensor according to an  
25 exemplary embodiment of the present invention, for example, in a gear box of a  
motorcar. The upper portion of Fig. 56 shows the arrangement of the PCME torque  
sensor according to an exemplary embodiment of the present invention. The lower  
portion of the Fig. 56 shows the arrangement of a stand alone sensor device which is

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not integrated in the input shaft of the gear box as is in the exemplary embodiment of the present invention.

- As may be taken from the upper portion of Fig. 56, the torque sensor according to an exemplary embodiment of the present invention may be integrated into the input shaft of the gear box. In other words, the primary sensor may be a portion of the input shaft. In other words, the input shaft may be magnetically encoded such that it becomes the primary sensor or sensor element itself. The secondary sensors, i.e. the coils, may, for example, be accommodated in a bearing portion close to the encoded region of the input shaft. Due to this, for providing the torque sensor between the power source and the gear box, it is not necessary to interrupt the input shaft and to provide a separate torque sensor in between a shaft going to the motor and another shaft going to the gear box as shown in the lower portion of Fig. 56.
- Due to the integration of the encoded region in the input shaft it is possible to provide for a torque sensor without making any alterations to the input shaft, for example, for a car. This may be important, for example, in parts for an aircraft where each part has to undergo extensive tests before being allowed for use in the aircraft. Such torque sensor according to the present invention may be perhaps even without such extensive testing being incorporated in shafts in aircraft or turbine since, the immediate shaft is not altered. Also, no material effects are caused to the material of the shaft.

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Furthermore, as may be taken from Fig. 56, the torque sensor according to an exemplary embodiment of the present invention may allow to reduce a distance between a gear box and a power source since the provision of a separate stand alone torque sensor between the shaft exiting the power source and the input shaft to the gear box becomes obvious.

Next, Sensor Components will be explained.

A non-contact magnetostriction sensor (NCT-Sensor), as shown in Fig.57, may consist, according to an exemplary embodiment of the present invention, of three main functional elements: The Primary Sensor, the Secondary Sensor, and the Signal Conditioning & Signal Processing (SCSP) electronics.

Depending on the application type (volume and quality demands, targeted manufacturing cost, manufacturing process flow) the customer can chose to purchase either the individual components to build the sensor system under his own management, or can subcontract the production of the individual modules.

Fig.58 shows a schematic illustration of components of a non-contact torque sensing device. However, these components can also be implemented in a non-contact position sensing device.

In cases where the annual production target is in the thousands of units it may be more efficient to integrate the "primary-sensor magnetic-encoding-process" into the customers manufacturing process. In such a case the customer needs to purchase application specific "magnetic encoding equipment".

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In high volume applications, where cost and the integrity of the manufacturing process are critical, it is typical that NCTE supplies only the individual basic components and equipment necessary to build a non-contact sensor:

- 5        ☐ ICs (surface mount packaged, Application-Specific Electronic Circuits)
- ☐ MFS-Coils (as part of the Secondary Sensor)
- ☐ Sensor Host Encoding Equipment (to apply the magnetic encoding on the shaft = Primary Sensor)

- 10       Depending on the required volume, the MFS-Coils can be supplied already assembled on a frame, and if desired, electrically attached to a wire harness with connector. Equally the SCSP (Signal Conditioning & Signal Processing) electronics can be supplied fully functional in PCB format, with or without the MFS-Coils embedded in the PCB.

15

**Fig.59** shows components of a sensing device.

- As can be seen from **Fig.60**, the number of required MFS-coils is dependent on the expected sensor performance and the mechanical tolerances of the physical sensor
- 20       design. In a well designed sensor system with perfect Sensor Host (SH or magnetically encoded shaft) and minimal interferences from unwanted magnetic stray fields, only 2 MFS-coils are needed. However, if the SH is moving radial or axial in relation to the secondary sensor position by more than a few tenths of a millimeter, then the number of MFS-coils need to be increased to achieve the desired
- 25       sensor performance.

In the following, a control and/or evaluation circuitry will be explained.



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The SCSP electronics, according to an exemplary embodiment of the present invention, consist of the NCTE specific ICs, a number of external passive and active electronic circuits, the printed circuit board (PCB), and the SCSP housing or casing. Depending on the environment where the SCSP unit will be used the casing has to be  
5 sealed appropriately.

Depending on the application specific requirements NCTE (according to an exemplary embodiment of the present invention) offers a number of different application specific circuits:

10

- ☐ Basic Circuit
- ☐ Basic Circuit with integrated Voltage Regulator
- ☐ High Signal Bandwidth Circuit
- ☐ Optional High Voltage and Short Circuit Protection Device
- 15 ☐ Optional Fault Detection Circuit

**Fig.61** shows a single channel, low cost sensor electronics solution.

As may be taken from Fig. 61, there may be provided a secondary sensor unit which  
20 comprises, for example, coils. These coils are arranged as, for example, shown in Fig. 60 for sensing variations in a magnetic field emitted from the primary sensor unit, i.e. the sensor shaft or sensor element when torque is applied thereto. The secondary sensor unit is connected to a basis IC in a SCST. The basic IC is connected via a voltage regulator to a positive supply voltage. The basic IC is also  
25 connected to ground. The basic IC is adapted to provide an analog output to the outside of the SCST which output corresponds to the variation of the magnetic field caused by the stress applied to the sensor element.

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Fig.62 shows a dual channel, short circuit protected system design with integrated fault detection. This design consists of 5 ASIC devices and provides a high degree of system safety. The Fault-Detection IC identifies when there is a wire breakage anywhere in the sensor system, a fault with the MFS coils, or a fault in the electronic driver stages of the "Basic IC".

Next, the Secondary Sensor Unit will be explained.

The Secondary Sensor may, according to one embodiment shown in Fig.63, consist of the elements: One to eight MFS (Magnetic Field Sensor) Coils, the Alignment- & Connection-Plate, the wire harness with connector, and the Secondary-Sensor-Housing.

The MFS-coils may be mounted onto the Alignment-Plate. Usually the Alignment-Plate allows that the two connection wires of each MFS-Coil are soldered / connected in the appropriate way. The wire harness is connected to the alignment plate. This, completely assembled with the MFS-Coils and wire harness, is then embedded or held by the Secondary-Sensor-Housing.

The main element of the MFS-Coil is the core wire, which has to be made out of an amorphous-like material.

Depending on the environment where the Secondary-Sensor-Unit will be used, the assembled Alignment Plate has to be covered by protective material. This material can not cause mechanical stress or pressure on the MFS-coils when the ambient temperature is changing.

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In applications where the operating temperature will not exceed +110 deg C the customer has the option to place the SCSP electronics (ASIC) inside the secondary sensor unit (SSU). While the ASIC devices can operated at temperatures above +125 deg C it will become increasingly more difficult to compensate the temperature related signal-offset and signal-gain changes.

The recommended maximal cable length between the MFS-coils and the SCSP electronics is 2 meters. When using the appropriate connecting cable, distances of up to 10 meters are achievable. To avoid signal-cross-talk in multi-channel applications (two independent SSUs operating at the same Primary Sensor location = Redundant Sensor Function), specially shielded cable between the SSUs and the SCSP Electronics should be considered.

When planning to produce the Secondary-Sensor-Unit (SSU) the producer has to decide which part / parts of the SSU have to be purchased through subcontracting and which manufacturing steps will be made in-house.

In the following, Secondary Sensor Unit Manufacturing Options will be described.

When integrating the NCT-Sensor into a customized tool or standard transmission system then the systems manufacturer has several options to choose from:

- ☐ custom made SSU (including the wire harness and connector)
- ☐ selected modules or components; the final SSU assembly and system test may be done under the customer's management.
- ☐ only the essential components (MFS-coils or MFS-core-wire, Application specific ICs) and will produce the SSU in-house.

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Fig.64 illustrates an exemplary embodiment of a Secondary Sensor Unit Assembly.

Next, a Primary Sensor Design is explained.

- 5    The SSU (Secondary Sensor Units) can be placed outside the magnetically encoded SH (Sensor Host) or, in case the SH is hollow, inside the SH. The achievable sensor signal amplitude is of equal strength but has a much better signal-to-noise performance when placed inside the hollow shaft.
- 10   Fig.65 illustrates two configurations of the geometrical arrangement of Primary Sensor and Secondary Sensor.

- Improved sensor performances may be achieved when the magnetic encoding process is applied to a straight and parallel section of the SH (shaft). For a shaft with
- 15   15 mm to 25 mm diameter the optimal minimum length of the Magnetically Encoded Region is 25 mm. The sensor performances will further improve if the region can be made as long as 45 mm (adding Guard Regions). In complex and highly integrated transmission (gearbox) systems it will be difficult to find such space. Under more ideal circumstances, the Magnetically Encoding Region can be as short as 14 mm,
- 20   but this bears the risk that not all of the desired sensor performances can be achieved.

- As illustrated in Fig.66, the spacing between the SSU (Secondary Sensor Unit) and the Sensor Host surface, according to an exemplary embodiment of the present invention, should be held as small as possible to achieve the best possible signal quality.

25

Next, the Primary Sensor Encoding Equipment will be described.

An example is shown in Fig.67.

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Depending on which magnetostriction sensing technology will be chosen, the Sensor Host (SH) needs to be processed and treated accordingly. The technologies vary by a great deal from each other (ABB, FAST, FT, Kubota, MDI, NCTE, RM, Siemens, ...)

5 ... and so does the processing equipment required. Some of the available magnetostriction sensing technologies do not need any physical changes to be made on the SH and rely only on magnetic processing (MDI, FAST, NCTE).

While the MDI technology is a two phase process, the FAST technology is a three

10 phase process, and the NCTE technology a one phase process, called PCM Encoding.

One should be aware that after the magnetic processing, the Sensor Host (SH or Shaft), has become a "precision measurement" device and has to be treated accordingly. The magnetic processing should be the very last step before the treated

15 SH is carefully placed in its final location.

The magnetic processing should be an integral part of the customer's production process (in-house magnetic processing) under the following circumstances:

- 20     ☐ High production quantities (like in the thousands)
- ☐ Heavy or difficult to handle SH (e.g. high shipping costs)
- ☐ Very specific quality and inspection demands (e.g. defense applications)

In all other cases it may be more cost effective to get the SH magnetically treated by a qualified and authorized subcontractor, such as NCTE. For the "in-house" magnetic

25 processing dedicated manufacturing equipment is required. Such equipment can be operated fully manually, semi-automated, and fully automated. Depending on the

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complexity and automation level the equipment can cost anywhere from EUR 20k to above EUR 500k.

5 In the following, referring to Fig.68, a position sensor array 100 according to a first embodiment of the invention will be described.

The position sensor array 100 comprises a reciprocating shaft 101 driven by a motor (not shown in Fig.68), wherein the reciprocating shaft 101 reciprocates along a reciprocation direction 102. Further, the position sensor array 100 comprises a  
10 position sensor device for determining a position of the reciprocating shaft 101. The position sensor device for determining a position of the reciprocating shaft 101 comprises one magnetically encoded region 103 integrated in a surface region of the reciprocating shaft 101. Further, the position sensor device comprises one detection  
15 coil 104, a measuring unit 105 for measuring a magnetic field based on the electrical signals provided by the detection coil 104, and a determining unit 106. The detection coil 104 is adapted to detect a signal generated by the magnetically encoded region 103 when the magnetically encoded region 103 reciprocating with the reciprocating shaft 101 passes a surrounding area of the detection coil 104. In this surrounding area, a present magnetic element can be detected by the detection coil 104. The  
20 determining unit 106 is adapted to determine the position of the reciprocating shaft 101 based on the detected signal, which is measured by a measuring unit 105 coupled with the detection coil 104.

The magnetically encoded region 103 is realized according to the PCME technology  
25 described above. Therefore, the magnetically encoded region 103 is a permanent magnetic region having a circumferentially magnetized region of the reciprocating shaft 101 made from industrial steel. The magnetically encoded region 103 is formed by a first magnetic flow region oriented in a first direction and by a second magnetic

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flow region oriented in a second direction, wherein the first direction is opposite to the second direction. In a cross-sectional view of the cylindrical reciprocating shaft 101 perpendicular to the paper plane of Fig.68 and perpendicular to the reciprocating direction 102 of the reciprocating shaft 101, there is a first circular magnetic flow  
5 having the first direction and a first radius and the second circular magnetic flow having the second direction and a second radius, wherein the first radius is larger than the second radius.

When the reciprocating shaft 101, driven by an engine which is not shown in Fig.68,  
10 reciprocates along the reciprocation direction 102, i.e. oscillates along a direction 102 from left to right and vice versa, the magnetic flux through the detection coil 104 generated by the magnetically encoded region 103 varies with the time, since the magnetically encoded region 103 has a time dependent distance from the detection coil 104. Thus, depending on the actual position of the reciprocating shaft 101, the  
15 induced voltage in the detection coil 104 yielding a signal in the measuring unit 105, varies dependent of the actual position of the reciprocating shaft 101. Based on this measured signal, the determining unit 106 determines the actual position of the reciprocating shaft. The determining unit 106 provides this position information to the control unit 107 which uses this information to regulate control signals for  
20 controlling the reciprocation of the reciprocating shaft 101.

In the following, referring to Fig.69, a position sensor array 200 according to a second embodiment of the invention will be described.

25 In contrast to the position sensor array 100, the position sensor array 200 comprises a plurality of magnetically encoded regions divided in a first group 201 of magnetically encoded regions and a second group 202 of magnetically encoded regions which are provided at different locations on the reciprocating shaft 101.

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Instead of the detection coil 104, the position sensor array 200 comprises a first Hall-probe 203, a second Hall-probe 204 and third Hall-probe 205 arranged along the reciprocating shaft 101. When the reciprocating shaft 101 reciprocates along a reciprocation direction 102, the plurality of magnetically encoded regions 201, 202  
5 pass the Hall-probes 203 to 205 to produce a significant and unique time dependent signal pattern detected by the Hall-probes 203 to 205 and measured by the measuring unit 105, so that the determining unit 106 can calculate the position of the reciprocating shaft 101 based on the sequence of signals.

10 Thus, the position sensor array 200 allows to sense the actual position of the reciprocating shaft 101 on the basis of the PCME technology in cascading sequence. The PCME encoding field group 201, 202 magnetically encoded regions have a different length along the reciprocation direction 102, whereby on one side of the reciprocating shaft 101 the shorter PCME encoding region 201 is placed and at the  
15 other end of the shaft 101 is the wider PCME encoding region 202.

The reciprocating shaft 101 is a hydraulic work cylinder. As can be seen from Fig.69, the short magnetic position markers 201 are cascaded, and the long magnetic position markers 202 are cascaded.

20

In the following, referring to Fig.70, a position sensor array 300 according to a third embodiment of the invention will be described.

The position sensor array 300 differs from the position sensor array 100 in that a  
25 plurality of equal-width magnetically encoded regions 301 are provided. Each of the magnetically encoded regions 301 has an equal width,  $l$ , along the reciprocating shaft 101. The magnetically encoded regions 301 are provided at different distances from one another, namely a distances of  $d$ ,  $2d$ , and  $3d$ . In contrast to the horizontally



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aligned detection coil 104 of Fig.68, Fig.70 shows a plurality of vertically aligned detection coils 302 having their coil axis arranged vertically according to the drawing of Fig.70. The different distances between adjacent magnetically encoded regions and adjacent detection coils 302 yield a time dependent pattern of signals generated  
5 in the detection coils 302 which allow to retrieve the actual position and velocity of the reciprocating shaft 101.

The arrangement of the coils 302 with respect to the magnetically encoded regions 301 is symmetric, i.e. in a reference state of the reciprocating shaft 101 shown in  
10 Fig.70, a central axis of each of the coils 302 equals to a central axis of a corresponding one of the magnetically encoded regions 301.

In the following, referring to Fig.71, a position sensor array 400 according to a fourth embodiment of the invention will be described.  
15

In the case of the position sensor array 400, a single horizontally aligned detection coil 104 is provided, and three equal-width magnetically encoded regions 301. When the shaft 101 reciprocates along direction 102, a detection signal is detected by the horizontally aligned detection coil 104 each time that one of the equal-width  
20 magnetically encoded regions 301 passes a close vicinity of the horizontally aligned detection coil 104. Thus, a sequence of signals is detected at the detection coil 104 which allows to recalculate the actual position of the shaft 101.

In the following, referring to Fig.72, a position sensor array 500 according to a fifth  
25 embodiment of the invention will be described.

The position sensor array 500 includes two ferromagnetic rings 501 attached on different portions of the reciprocating shaft 101. These ferromagnetic rings 501 made

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of iron material are separate ferromagnetic elements which are attached on the reciprocating shaft 101 to form magnetically encoded regions. Further, two horizontally aligned detection coils 104 are provided to measure a time dependent magnetic field via an induction voltage which is generated in a respective one of the coils 104 when one of the ferromagnetic rings 501 passes one of the horizontally aligned detection coils 104. As can be seen from the reference position of the reciprocating shaft 101 shown in Fig.72, the ferromagnetic rings 501 are provided at positions of the shaft 101 which are non-symmetric with respect to the detection coils 104. In other words, in a configuration in which the position of the detection coil 104 shown on the left hand side of Fig.72 corresponds to the position of the ferromagnetic ring 501 shown on the left hand side of Fig.72, there is an offset between the position of the centre of the detecting coil 104 shown on the right hand side of Fig.72 and the position of the central axis of the ferromagnetic ring 501 shown on the right hand side of Fig.72. Consequently, the detection signals of the different coils 104 are timely shifted with respect to each other. Such a time offset yields further position information of the reciprocating shaft 101.

Referring to Fig.73, a diagram 600 will be described showing a signal curve 603 which can be detected by the coils 104 shown in Fig.71 when one of the magnetically encoded regions 301 passes the respective coil 104. Along an abscissa 601 of diagram 600, the position  $x$  of the reciprocating shaft 101 is shown, and along an ordinate 602, a signal amplitude  $A(x)$  is shown. Thus, the signal curve 603 allows to determine the position of the reciprocating shaft 101.

In the following, referring to Fig.74, a position sensor array 700 according to a sixth embodiment of the invention will be described. In contrast to the position sensor array 100, the position sensor array 700 shows an entirely magnetized shaft 701, i.e.

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a shaft which is entirely made of ferromagnetic material or a shaft which is magnetized along its entire length according to the PCME technology.

Fig.75 shows a diagram 800 having an abscissa 801 along which the position  $x$  of the entirely magnetized shaft 701 having a total length  $L$  is shown. Along an ordinate 802 of diagram 800, the amplitude  $A(x)$  of a signal detected by the determining unit 106 is shown. Thus, the signal of Fig.75 allows a unique identification of the actual position of the entirely magnetized shaft 701 of Fig.74.

10 In the following, referring to Fig.76, a position sensor array 900 according to a seventh embodiment of the invention will be described.

In the case of the position sensor array 900, the reciprocating shaft 101 is divided into a plurality of equally spaced first to fourth segments 901 to 904. Each segment 15 901 to 904 comprises one magnetically encoded region 301, the magnetically encoded regions 301 being arranged in an asymmetric manner along the segments 901 to 904. The magnetically encoded region 301 of the first segment 901 is arranged in the very left part, the magnetically encoded region 301 of the second segment 902 is arranged in the middle-left part, the magnetically encoded region 301 20 of the third segment 903 is arranged in the middle-right part and the magnetically encoded region 301 of the fourth segment 904 is arranged at the very right part of the respective segment. Thus, the arrangement of the magnetically encoded regions 301 is shifted from segment to segment 901 to 904. This yields a unique signal pattern detectable by the coils 302 which allows an accurate estimation of the actual position 25 of the shaft 101.

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The equally spaced segments 901, 904 with different locations of the markers 301 allow an estimation of the position of the reciprocating shaft 101 by evaluating the signals detected by the coils 302.

- 5 In the following, referring to Fig.77, a concrete processing apparatus 1000 according to a first embodiment of the invention will be described.

The concrete processing apparatus 1000 is provided on a truck (not shown) equipped with a concrete mixer pump for mixing concrete material using a reciprocating shaft  
10 having the magnetic encoding of the invention. Thus, a concrete pump is equipped with a hydraulically driven work cylinder, i.e. a reciprocating shaft. In order to securely control the function of the reciprocating shaft, the position of the shaft should be known exactly. The invention provides a method of determining the exact position of the reciprocating cylinder of the concrete processing apparatus 1000.

15

Fig.77 shows the concrete processing apparatus 1000 having a concrete processing chamber 1001 which includes an inlet 1003 for supplying concrete material 1005 in the concrete processing chamber 1001. A reciprocating work cylinder 1002 mixes the concrete material 1005 by reciprocating along a reciprocation direction 102 and  
20 transports the concrete material 1005 to a concrete outlet 1004 connected to a pipeline (not shown) via which the concrete is supplied to a concrete consumer.

The reciprocating work cylinder 1002 has, on its reciprocating shaft, three magnetically encoded regions 301 manufactured according to the PCME technology.  
25 Sealing elements 1007 are provided to prevent an undesired mixture of concrete material 1005 with a hydraulic fluid 1006 provided to drive the reciprocating work cylinder 1002. When the magnetically encoded regions 301 pass a detection coil 104, an induction voltage is generated in the coil 104 which is supplied to the measuring

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unit 105 and which allows the determining unit 106 to estimate the present position of the reciprocating work cylinder 1002. A position indicating signal, in which the actual position of the cylinder 1002 is encoded, is provided to a control unit 107 which uses the position information to optimize a driving control signal to drive the  
5 reciprocating work cylinder 1002.

Thus, the invention improves the quality of the generated concrete 1005 and the operation of the reciprocating work cylinder 1002, by enabling an improved way of driving the work cylinder 1002 based on position information of the cylinder 1002.  
10

In the following, referring to Fig.78, a concrete processing apparatus 1100 according to a second embodiment of the invention will be described.

Fig.78 shows a twin cylinder pump arrangement having a first working cylinder 1002 and a second work cylinder 1102 which allows a combination of steady and gentle  
15 pumping patterns. Hydraulic oil 1006 is pumped under pressure to the working cylinders 1002, 1102. At one time, one of the working cylinders 1002, 1102 extends, while the other one retracts at the same time. Thus, one cylinder 1002, 1102 pumps and draws in concrete material 1005, and the other cylinder 1102, 1002 pumps  
20 concrete material 1005 into a connected pipeline (not shown). The assembly of Fig.78 is mounted on a truck to form a machine which is applicable in the construction and civil engineering fields.

In contrast to the concrete processing apparatus 1000, two instead of one work  
25 cylinders 1002, 1102 are provided in the case of the concrete processing apparatus 1100, namely the reciprocating work cylinder 1002 and a further reciprocating work cylinder 1102. Moreover, a further concrete inlet 1101 for supplying concrete

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material in a symmetric manner is provided. Both of the reciprocating work cylinders 1002, 1102 are hydraulically driven using the hydraulic fluid 1006.

- According to the operation mode shown in Fig.78, the reciprocating work cylinder
- 5 1002 moves along a first direction 1103, whereas the further reciprocating work cylinder 1102 moves along a second direction 1104 which is opposite to the first direction 1103. A separation wall 1105 separates the reciprocating work cylinders 1002, 1102 from each other. Along the shaft of each of the reciprocating cylinders 1002, 1102, a plurality of magnetic encoded regions 301 are provided which produce
- 10 magnetic signals on coils 104. Each reciprocating cylinder 1002, 1102 has assigned a pair of coils 104 having opposed coil axis, so that an evaluation of the signals generated in the coils 104 of each pair of coils allow to eliminate the influence of the magnetic field of the earth to further improve the accuracy of the detected positions.
- 15 In the following, further embodiments of the invention will be described which may or may not be realized with PCME technology.

- Fig.79 and Fig.80 show schematic views illustrating a sequence of signals 6810 captured by three magnetic field detectors 6800, 6801, 6802 generated by six
- 20 magnetic encoded regions (see "1" to "6") provided with (from left to right) increasing distances from one another on a reciprocating shaft (not shown) of a position sensor array according to an eighth embodiment of the invention. A first pickup location 6820 and a second pickup location 6830 are shown. The six magnetic encoded regions (markers) have the same physical dimension (width of the
- 25 markers is constant), but the location in relation to each other is changing.

As can be seen from Fig.80, when using three pickup modules 6800, 6801, 6802, then the usable axial-measurement range is much larger than in a scenario of using

one or two pickup modules, since there are no “dead” areas (at least two pickup devices have a usable signal at any given location, at any point of time).

- Fig.81 and Fig.82 show schematic views illustrating a sequence of signals 7000 captured by two magnetic field detectors 6800, 6801 generated by six magnetic encoded regions (see “1” to “6”) provided with (from left to right) increasing distances from one another provided on a reciprocating shaft (not shown) of a position sensor array according to a ninth embodiment of the invention.
- 10 When using two pickup devices 6800, 6801, the axial measurement range expands considerably than when using only one pickup device. However, there are still “dead” areas 7100 between the markers where there is no sufficient information available through the pickup system. Apart from the “dead” areas 7100, the axial position can be determined accurately. Two pickups enable to determine accurately
- 15 the axial position when two signals are present at any given location.

- Fig.83 shows a schematic view illustrating a sequence of signals 6810 captured by one magnetic field detector 6800 generated by six magnetic encoded regions (see “1” to “6”) provided with (from left to right) increasing distances from one another
- 20 provided on a reciprocating shaft (not shown) of a position sensor array according to a tenth embodiment of the invention. This embodiment allows to obtain axial position information with low effort.

- Fig.84 to Fig.86 show a hollow tube 7300 as reciprocating object with different
- 25 embodiments for magnetic encoded regions arranged inside the hollow tube. The magnetic field generated inside the tube 7300 has to be strong enough to penetrate the outer tube wall.

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According to the embodiment shown in Fig.84, a permanent magnet 7301 (synthetic magnet) is placed inside the tube.

According to the embodiment shown in Fig.85, a coil 7400 (inductor) is placed  
5 inside the tube which can be magnetized by an electrical power source 7401.

According to the embodiment shown in Fig.86, a helical coil 7500 is placed inside the tube which can be magnetized by an electrical power source 7401.

10 Fig.87, Fig.88 show a position sensor array 7600 according to an eleventh embodiment of the invention.

In an automatic automotive gearbox system, as shown in Fig.87, Fig.88, the position of the various tooth-wheels (gear-wheels) are changed by push-pull-rods 7601. In a  
15 passenger car gearbox system may be particularly four or more push-pull-rods 7601 to control the gear positions of the cars transmission system. The push-pull-rods 7601 may be operated by an electric or pneumatic or hydraulic actuator. The actuators operate a hook 7602 which is inserted into a hole from the push-pull-rod 7601.

20 The push-pull-rod may 7601 move as little as +/-10 mm (passenger car gearbox) or much more (truck gearbox). The optimal operation of the gearbox requires that the push-pull-rods 7601 are moved to precise positions with little tolerances.

25 As the axial measurement range is relatively short (+/-10mm, up to +/-20mm) only one magnetic marker 103 is required for measuring the position of the push-pull-rod 7601. The magnetic marker 103 can be placed at any desired location of the push-pull-rod 7601 whereby the cross-section of the push-pull-rod 7601 where the marker



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103 will be placed can be round, square, rectangle, or any other desired shape. As the push-pull-rod 7601 does not rotate, a non-uniform (non-round) shape of the rod's cross section is acceptable.

- 5 Fig.87 shows a typical gearbox push-pull-rod 7601 design, required to change the gear (tooth-wheel) position inside the gearbox by means of an externally placed actuator. The actuator is attached to the hook 7602 which is attached to the end of the push-pull-rod 7601.
- 10 Fig.88 shows a detailed view of the push-pull-rod 7601 with an magnetic marker encoding 103 and at least one magnetic field detecting device 104. The magnetic field detecting device 104 (example: coil) will detect the exact axial (linear) position of the push-pull-rod 7601 in relation to the position of the magnetic field detecting device 104.

15

It should be noted that the term "comprising" does not exclude other elements or steps and the "a" or "an" does not exclude a plurality. Also elements described in association with different embodiments may be combined.

20